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1 **Methodologies, technologies and strategies for acoustic streaming based**
2 **Acoustofluidics**

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43

44 **Abstract**

45 Acoustofluidics offers contact-free manipulation of particles and fluids, enabling their uses in
46 various life sciences, such as for biological and medical applications. Recently there have been
47 extensive studies on acoustic streaming based acoustofluidics, which are formed inside a liquid
48 agitated by leaky surface acoustic waves (SAWs) through applying radio-frequency signals to
49 interdigital transducers (IDTs) on a piezoelectric substrate. This paper aims to describe acoustic
50 streaming based acoustofluidics and provide readers with an unbiased perspective to determine
51 which IDT structural designs and techniques are most suitable for their research. This review
52 firstly qualitatively and quantitatively introduces underlying physics of acoustic streaming.
53 Then it comprehensively discusses the fundamental designs of IDT technology for generating
54 various types of acoustic streaming phenomena. Acoustic streaming related methodologies and
55 the corresponding biomedical applications are highlighted and discussed, according to either
56 standing surface acoustic waves or travelling surface acoustic waves generated, and also sessile
57 droplets or continuous fluids used. Travelling SAW based acoustofluidics generate various
58 physical phenomena including mixing, concentration, rotation, pumping, jetting,
59 nebulization/atomization, and droplet generation, as well as mixing and concentration of liquid
60 in a channel/chamber. Standing SAWs induces streaming for digital and continuous
61 acoustofluidics, which can be used for mixing, sorting, and trapping in a channel/chamber. Key
62 challenges, future developments and directions for acoustic streaming based acoustofluidics
63 are finally discussed.

64

65 **Keywords:** Acoustic Streaming, Surface Acoustic Wave, Interdigital Transducer,
66 Acoustofluidics

67 **1. Introduction**

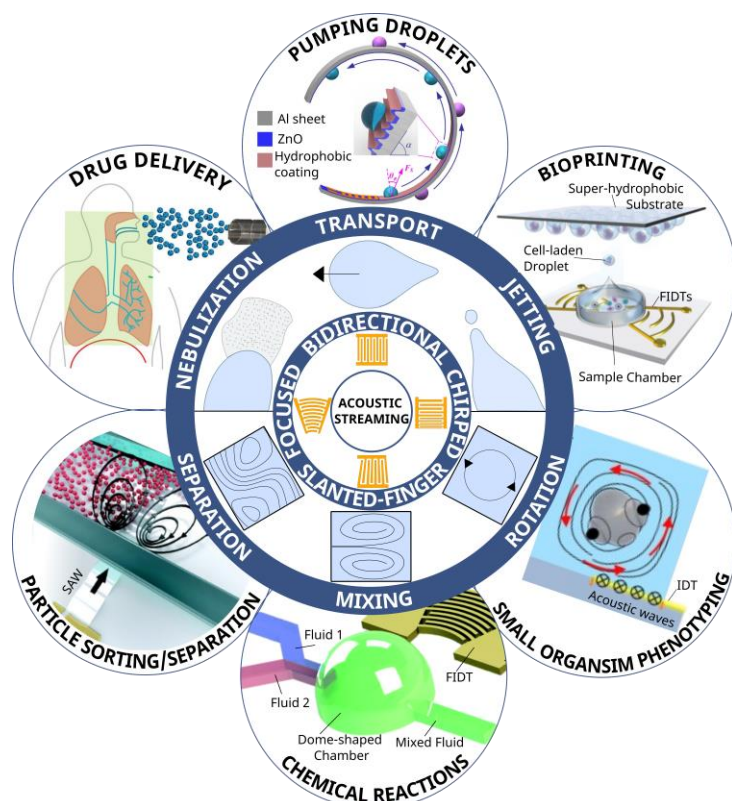
68 Interactions between acoustics and fluids have been well known for thousands of years. For
69 example, the ancient Chinese spouting bowl (or called resonance bowl) was employed
70 spiritually for meditation to promote healing ¹. It used the vibrations generated from rubbing
71 the handles to form standing waves which cause water droplets to be ejected above the water
72 surface and form various fascinating patterns ². However, it was until year 1866 that research

73 on acoustic streaming was emerged when Kundt's tube experiment was designed to measure
74 the speed of sound in a fluid ³. By rubbing a metal rod resonator at the end of a tube in which
75 the fluid contained small particles, these particles were periodically patterned and clustered
76 over time at the nodes of the vibration due to the formation of standing waves ³. Acoustic
77 streaming was firstly reported by Dvorak in 1876 using the Kundt's tube ⁴. He observed that
78 the air was flowing from the node towards the antinodes along the axis of the tube, while the
79 flow of the air near the wall was directed in the opposite direction ⁵. This observation led to the
80 first theoretical model derived by Rayleigh in 1884 ⁶, and was further studied almost a century
81 later by various scientists including Schlichting (1932) ⁷ (who solved the incompressible
82 streaming mechanisms near the wall), Westervelt (1953) ⁸ and Nyborg (1953) ⁹ (both of whom
83 extended the methodology for a compressible fluid at its first-order perturbation).

84 Acoustic streaming frequently occurs in fluidics, and it generates regions of recirculation,
85 pressure gradients, both of which can be used for particle manipulation such as patterning ¹⁰,
86 concentration ^{11,12}, and separation ^{13,14}. Particle manipulation is a widely studied topic which
87 is related to the precise control of the dynamics of particles in biological samples. It can be
88 realized by various passive methods, such as deterministic lateral displacement, pinched flow
89 fractionation, crossflow filtration, hydrodynamic filtration, and inertial microfluidics ¹⁵.
90 Although these methods are often advantageous owing to their simplicity and low costs, they
91 do not always offer precise and on-demand control in comparison to many active methods
92 involving external forces or fields, such as magnetic ¹⁶, electrical (e.g., based on electrokinetic
93 ¹⁷ effects such as free-flow electrophoresis ¹⁸ and dielectrophoresis ¹⁹), optical ^{20 21}, and
94 ultrasonics or acoustic wave forces. Among these active methods, acoustic wave based ones
95 have the advantage of manipulating various bioparticles, from nanometer-sized extracellular
96 vesicles to micrometer-sized circulating tumor cells (CTCs), with considerable throughputs
97 and high compatibility ²²⁻²⁶. These devices are not only non-invasive, label-free, and
98 contactless, but also convenient to be integrated with other systems for multifunctionality
99 ^{25,27,28}.

100 Acoustic streaming can also generate acoustic pressure or force to perform operations such as
101 deformation, transportation and manipulation of bulk fluid, namely jetting ^{29,30}, nebulization or
102 atomization ³¹⁻³⁴, microscale streaming ³⁵, object rotation ^{36,37}. All of these have established a
103 myriad of emerging medical applications. Figure 1 schematically illustrates examples of
104 generation of acoustic streaming by using IDT techniques, and its methodologies and
105 applications. A handful of popular IDT designs (bidirectional IDT, chirped IDT, slanted-finger

106 IDT, and focused IDT) are shown in the center. Figure 1 also include examples of acoustic
 107 streaming based acoustofluidic applications (drug delivery ³⁸, bioprinting ³⁹, pumping droplets
 108 ⁴⁰, small organism phenotyping ³⁶, chemical reactions ⁴¹, particle sorting/separation ¹¹) and their
 109 respective methodology (nebulization, jetting, transport, rotation, mixing, separation,
 110 trapping). Overall, Figure 1 displays a glimpse of the possibilities that acoustic streaming based
 111 acoustofluidics could offer. Although this phenomenon is well known and widely studied for
 112 decades, it has only recently been attracted for microfluidic applications as it overcomes a lot
 113 of challenges, which are caused by low Reynolds numbers of micro- or nanoscale liquids, either
 114 in sessile droplet format or a continuous fluid within microchannels or microchambers ⁴²⁻⁴⁵.



115
 116 Figure 1. The generation of acoustic streaming by using IDT techniques, and its methodologies
 117 and applications. Popular IDT designs (Bidirectional IDT, Chirped IDT, Slanted-Finger IDT,
 118 and Focused IDT) are shown in the center. Example methodologies generated by IDTs
 119 (nebulization, jetting, transport, rotation, mixing, separation) are illustrated in the middle circle,
 120 and relevant acoustic streaming applications based on the respective methodology (drug
 121 delivery ³⁸, bioprinting ³⁹, pumping droplets ⁴⁰, small organism phenotyping ³⁶, chemical
 122 reactions ⁴¹, particle sorting/separation ¹¹) are shown on the outer circle.

123 In-depth reviews of these ultrasonic or acoustic wave methods for particle manipulation and
124 acoustofluidic functions have previously been given by many researchers ^{2,27,46–51}. Although
125 these reviews have covered most critical information on fundamental mechanisms and
126 chemical, biomedical, biological applications of acoustofluidics, acoustic sensors and lab-on-
127 a-chip, none of them are focused on the advances in methodology and techniques based on
128 acoustic streaming for both liquid droplets and continuous flow liquids. Therefore, this paper
129 aims to focus on fundamental designs, techniques, and key applications of acoustic streaming,
130 providing qualitative and quantitative discussions of its mechanisms, and highlight its key
131 biological and medical applications (which can be revealed from Figure 1).

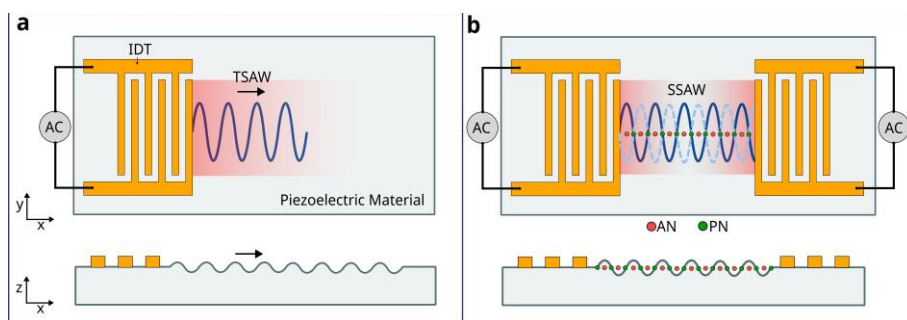
132 **2. Fundamental of surface acoustic waves**

133 Acoustic waves are generated by applying radio-frequency (RF) signals to electrodes which
134 are commonly patterned onto a piezoelectric substrate, such as quartz or lithium niobate
135 (LiNbO_3) or lithium tantalate (LiTaO_3). The resulted acoustic waves propagate either in the
136 direction perpendicular to the surface of the material into the bulk medium (bulk acoustic wave
137 or BAW), or along the surface of the material (surface acoustic wave or SAW). This review
138 mainly discusses SAWs, whose electrodes are consisted of two metallic interlocking comb-
139 shaped arrays called interdigital electrodes (IDEs) or interdigital transducers (IDTs), which
140 convert electrical energy into acoustic waves through the reversed piezoelectric effect. When
141 an RF voltage is applied to the IDTs, it causes alternating regions of tensile and compressive
142 strains between the fingers of the electrode, thus producing mechanical waves which can
143 propagate on the surface. IDTs have been extensively investigated in the past fifty years for
144 usages in RF communications or filters applications ^{52,53}, and radio-frequency identification
145 (RFID)^{52,54,55}. However, for acoustofluidic applications, this is a relatively new and an exciting
146 area to be explored ^{53,56}.

147
148 SAW devices can produce different types of surface wave modes to target various applications
149 ²⁸. Most SAW devices are designed to generate Rayleigh waves which propagate along the
150 surface of the substrate, with both longitudinal and vertical shear components. In Rayleigh
151 waves, particles on the surfaces have elliptical trajectory, and show a rapid decay of particle
152 oscillation with depth ⁵⁷. There are strong interactions of Rayleigh waves with the liquid (also
153 the particles inside), which enable them suitable for microfluidic applications. The velocity of
154 the waves is dependent on the material of the substrate and the orientation of the crystals. A
155 conventional Rayleigh SAW device typically consists of an IDT to create travelling surface

156 acoustic waves (TSAWs) as shown in Figure 2(a). If a pair of these identical IDTs are used and
 157 placed opposite to each other, two oppositely propagating TSAWs will interfere each other,
 158 creating a standing surface acoustic wave (SSAW), illustrated in Figure 2(b). These SSAWs
 159 produce pressure nodes (PNs) and antinodes (ANs) between two IDTs, which are often used
 160 for particle manipulation ^{58,59}.

161

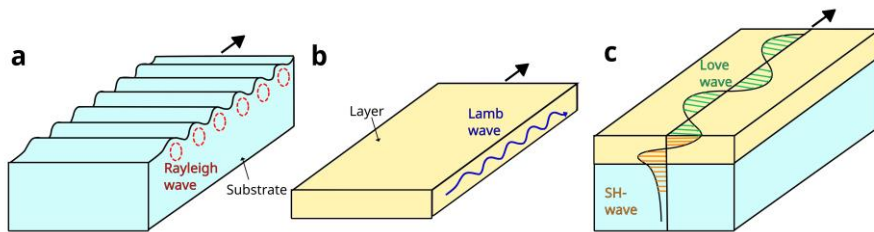


162

163 Figure 2. Schematic of the top and side views of SAWs generated by conventional IDT
 164 devices⁶⁰. (a) A single IDT producing TSAW. (b) A pair of opposite IDTs producing SSAW,
 165 demonstrating regions of PNs and ANs.

166

167 Apart from the fundamental Rayleigh waves (illustrated in Figure 3(a)), higher wave modes of
 168 SAWs in a layered SAW device are called Sezawa waves, which mainly propagate through the
 169 boundary or interlayers at a higher velocity than that at the top layer ⁵⁷. Lamb waves (Figure
 170 3(c)), which are often generated in thin plate or membranes, are similar to Rayleigh waves.
 171 However, they travel along the whole plate structure (i.e., along both upper and lower surfaces)
 172 and hence have two free surfaces as guiding boundaries, rather than just one free surface ⁶¹.
 173 Shear horizontal SAWs (SH-SAWs, Figure 3(b)) propagate on the substrate surface as well as
 174 on many piezoelectric thin films, all of which have in-plane crystal textures ⁶². Love waves
 175 occur in SH-SAWs (Figure 3(c)) whose surface is covered with a thin wave guide layer. The
 176 SH-SAWs and Love mode waves are mainly used for biosensing rather than microfluidic
 177 applications, due to their less damping effects or weak coupling with the liquid, compared with
 178 those of the Rayleigh ones ⁵⁷.



179

180 Figure 3. Illustration of types of wave propagation by means of their distribution of
 181 displacements⁶². (a) Rayleigh wave⁶³ (b) Lamb waves⁶⁴ (c) Shear horizontal waves and Love
 182 waves⁵⁷.

183

184 A typical SAW IDTs (using an SAW resonator as an example) include the electrode fingers,
 185 bus bars and electrode pad, and in many cases, the reflectors. For biosensing or medical
 186 diagnosis applications, these SAW devices are required to achieve higher SAW frequencies,
 187 larger amplitude, smaller width (higher quality factor), reduced noises, and precise IDT
 188 dimensions. SAW devices with frequencies from tens of MHz up to tens of GHz with high
 189 quality factor and low noise have been extensively reported ^{64–67}. Whereas for microfluidics
 190 applications, these SAW devices are required to generate multiple microfluidic functions which
 191 often require higher output powers, higher vibration amplitudes, various types of wave modes,
 192 possible wider range frequencies (e.g., from low frequency of a few MHz up to a few hundred
 193 MHz). Some high frequency SAW devices (e.g., a few hundreds of MHz) were explored for
 194 manipulating nanoscale droplet, single cells or sub-micron particles ^{68,69}.

195

196 When designing SAW IDTs, there are different issues to be considered, e.g.,
 197 geometry/thickness, electrode materials selections, mass loading, piezoelectric shorting,
 198 electrical regeneration and geometric discontinuity, strength of electromechanical constant and
 199 metallization patterns ^{70,71}. Recently many studies have been done on the design and patterning
 200 of various types of electrodes for lab-on-a-chip applications (including bio-samples functions
 201 and precise sensing functions), and more importantly, to improve microfluidic functions ^{53,56}.
 202 However, currently available IDT designs are purposely developed for RF communication or
 203 various sensing applications, and not specifically focused on their designs for the optimum
 204 acoustofluidics functions ²⁵. Therefore, in this paper, we will firstly introduce the mechanisms
 205 of acoustic streaming and acoustofluidics, and then discuss various IDT designs and their
 206 relevant application to acoustofluidics.

207 3. Mechanisms of acoustic streaming and Acoustofluidics

208 Acoustic streaming is a phenomenon that occurs in different forms due to its sensitivity to
209 various geometries and boundary conditions. It is observed in Newtonian fluids, superfluid and
210 non-Newtonian viscoelastic liquids, thus have found various applications ⁷². This section aims
211 to provide the key information about generation mechanisms of acoustic streaming and
212 describe the fundamental theories given its ubiquitous appearance.

213 3.1. Governing equations and related forces

214 Acoustic streaming can be analyzed quantitatively using fluid dynamics' well-known continuity
215 and momentum equations, assuming the fluid is homogeneous and isotropic, i.e., ²

$$\frac{\partial \rho}{\partial t} + \nabla \cdot (\rho \mathbf{v}) = 0 \quad 1a$$

$$\rho \frac{\partial \mathbf{v}}{\partial t} + \rho (\mathbf{v} \cdot \nabla) \mathbf{v} = -\nabla p + \mu \nabla^2 \mathbf{v} + \left(\mu_b + \frac{\mu}{3} \right) \nabla \nabla \cdot \mathbf{v} \quad 1b$$

216 where \mathbf{v} is the flow velocity, t is time, p is the pressure of a fluid, μ_b and μ are the bulk and
217 the shear viscosities of the fluid, respectively. The bold represent vectors, and the normal are
218 the scalars. For simplicity, all the external fields such as gravity, buoyance, and
219 electromagnetism have not been considered. As only the isothermal case has been considered
220 in many cases, the heat transfer equation is normally not required ⁷³. The left side of equation
221 1 is the inertia force per unit volume of fluid. The first term is the unsteady acceleration, and
222 the second term is the convective acceleration. Convective acceleration is associated with the
223 Reynolds stress ². The net forces per unit volume on the right side include pressure gradient
224 and viscosity gradients ⁷⁴. These equations can be used with the boundary conditions and the
225 linear relationship between pressure p and mass density ρ to predict the motion of the fluid ⁷⁵.

$$p = c_0^2 \rho \quad 2$$

226 where c_0 is the speed of sound in the fluid. Nevertheless, these equations are difficult to solve
227 analytically. The only concept with a thorough foundation is perturbation theory which can
228 only be used for slow streaming²⁷. The liquid flow has two components, i.e., the fluids acoustic
229 motion and the streaming motion. Slow streaming is generated when the velocity of the
230 acoustic component is greater than the steaming component and only encounters resistance
231 from viscosity ²⁷. It is often called linear streaming as the second-order governing differential
232 equations in the perturbation expansion are linear, and the convective acceleration is thus
233 disregarded. Although being called linear streaming, it should be noted that this streaming is

234 still caused by many nonlinear effects ⁷⁶. Whereas fast streaming is generated when the
 235 streaming velocity is in the same order or larger than the acoustic component. The nonlinear
 236 component is included such that convective acceleration needs to be considered. This paper is
 237 mostly focused on the theory of slow streaming.

238 Reynolds number (R_e) is a parameter used to describe the characteristics of the flow. It is the
 239 ratio of inertia to viscous terms. The flow is laminar when the viscous force dominates or
 240 turbulent when the inertia forces dominate. For slow streaming, the effect of inertia on the
 241 streaming motion is neglected by comparison to viscous effects and hence slow streaming
 242 occurs when the flow is laminar. Whereas, for fast streaming, the effect of inertia cannot be
 243 neglected hence $R_e > 1$. Reynolds number is dependent on the flow velocity and the fluid
 244 mechanical system ⁷⁷. It is defined as,

$$R_e \equiv \rho U_0 \mathcal{L} / \mu \quad 3$$

245 where \mathcal{L} is the characteristic length, $U_0 \equiv |\mathbf{U}|$ is the characteristic flow velocity, which
 246 includes both the velocity of the fluid \mathbf{v}_0 and the effect of the acoustic propagation $|\mathbf{U}| = \mathbf{v}_0 +$
 247 $\langle \rho_1 \mathbf{v}_1 \rangle / \rho_0$. Reynolds number for each streaming form uses a different length scale: Schlichting
 248 $\mathcal{L} = \delta_v$, Rayleigh $\mathcal{L} = \lambda$ and Eckart $\mathcal{L} = L$. δ_v is viscous penetration depth, and L is a
 249 characteristic length scale much larger than the acoustic wavelength λ ².

250 R_e is usually low in most of microfluidics due to their small dimensions. The flow is usually
 251 laminar, and no turbulence occurs. Using perturbation theory, the slow streaming can be
 252 modelled in a predictable linear manner. However, R_e can become quite high in cases of fast
 253 streaming, where the flow turns more unstable, and the nonlinear term needs to be considered
 254 in the analysis ^{2,75}.

255 3.1.1. Streaming Analysis with different flow velocity regimes

256 Perturbation theory is a method to find approximate solutions for a continuity and momentum,
 257 as shown in Eq. 3. A linearized form of these equations can be obtained by considering minor
 258 disturbances in density, pressure, and velocity;

$$p = p_0 + \varepsilon p_1 + \varepsilon p_2 + \dots \quad 4a$$

$$\rho = \rho_0 + \varepsilon \rho_1 + \varepsilon \rho_2 + \dots \quad 4b$$

$$\mathbf{v} = \mathbf{v}_0 + \varepsilon \mathbf{v}_1 + \varepsilon \mathbf{v}_2 + \dots \quad 4c$$

259 where subscripts 0, 1, and 2 represent static (absence of sound), first-order, and second-order
 260 quantities, respectively. In the absence of sound, the undisturbed state, \mathbf{v}_0 , is 0 as the fluid is

261 quiescent. The Mach number $\varepsilon = v_1/c_0$ is used as the smallness parameter ². It is defined as
262 the ratio of fluid velocity to the speed of sound. This method assumes that the successive
263 approximations converge, hence ε is sufficiently small and can only be used for slow streaming
264 analysis ². The successive approximations do not converge for fast streaming, and thus the
265 perturbation approach cannot be used.

266 The continuity and momentum equations can be solved for each order component of the
267 acoustic field by substituting the perturbation expansions. The first order acoustic field solution
268 describes the acoustic motions in the system that contains oscillatory motion, where \mathbf{v}_1 is the
269 acoustic velocity and p_1 is the acoustic pressure field. The first-order solutions can be
270 substituted into second-order equations and time-averaged to find the solution for acoustic
271 streaming, which contains both harmonic and steady components²⁷. Physically, the second-
272 order time-averaged velocity $\langle \mathbf{v}_2 \rangle$ is the acoustic streaming, and the second-order time-
273 averaged pressure $\langle p_2 \rangle$ produces to the acoustic radiation force that occurs when the acoustic
274 waves scatter on the particles, causing them to move⁷³.

275 Zaremba ⁷⁸ used a different approach which overcomes the perturbation method limitation,
276 allowing the acoustic streaming velocities to be larger than the particle velocities (e.g., in the
277 case of fast streaming). It can be done by decomposing the dependent variables in the fluid to
278 time-averaged streaming flow component and instantaneous first-order component. The
279 streaming motion can be solved by substituting into the continuity and momentum equations
280 and time averaging over the excitation period ².

281

282 3.1.2. Forces in acoustic streaming

283 The forces on particles exposed to an acoustic wave are those due to direct irradiation by the
284 acoustic field and indirect irradiation from scattering of the acoustic field from other objects ².
285 Primary acoustic radiation pressure (\mathbf{F}^{ARF}) describes the force acting on a single particle in a
286 fluid due to the SAW²⁷. Whereas secondary acoustic radiation pressure is the force due to the
287 acoustic interactions with other particles in the fluid²⁷. Depending on the particle's mechanical
288 properties, the particle moves towards the PN or AN due to the primary and secondary acoustic
289 radiation forces ^{27,79}.

290 Acoustic radiation force \mathbf{F}^{ARF} is determined by the surface integral of the time-averaged
 291 second-order pressure p_2 and momentum flux tensor $\rho_0 \langle \mathbf{v}_1 \mathbf{v}_1 \rangle$ at a fixed surface just beyond
 292 the oscillating sphere^{80,81}. Hence, the generalized equation can be written as:

$$\mathbf{F}^{ARF} = - \int_{\partial\Omega} da \{ \langle p_2 \rangle \mathbf{n} + \rho_0 \langle (\mathbf{n} \cdot \mathbf{v}_1) \mathbf{v}_1 \rangle \} \quad 5$$

293 where \mathbf{n} is the unit normal vector of the particle surface directed into the fluid.

294 Overall, the particles in a fluid are exposed to the net acoustic radiation force and the SAW
 295 acoustic streaming induced Stokes drag force \mathbf{F}^{drag} ⁸². The dominant force depends on the
 296 particles size. As a result, particles larger than a given threshold size will have their motion
 297 dictated by the acoustic radiation force.²⁷ The size threshold is dependent on factors such as
 298 actuation frequency, acoustic contrast factor, and kinematic viscosity⁸³.

299 The Stokes drag force, \mathbf{F}^{drag} , is dependent on particle size and shape, the fluid flow field, and
 300 the fluid viscosity⁸⁴. Hence on a spherical particle of radius r , with medium viscosity η and
 301 relative velocity v , \mathbf{F}^{drag} it is given by^{84,85}

$$\mathbf{F}^{drag} = 6\pi\eta r v \quad 6$$

302 Compared to traditional fluid mechanics, microfluidics has a number of significant forces
 303 which would otherwise be insignificant in larger scales². For a small scale, the fluid physics is
 304 dominated by surface tension and viscosity, whereas at a larger scale, body forces such as
 305 gravity are important². Other particle-particle interaction forces also exist, such as *van der*
 306 *Waals* interactions, electrostatic interactions and hydrophobic/hydrophilic effects⁸⁶.

307 **3.2. Fundamentals and mechanisms of acoustic streaming**

308 Acoustic streaming is a liquid flow phenomenon generated by forces arising from the presence
 309 of a gradient in the time-averaged acoustic momentum flux in a fluid^{86,87}. In a simple term, it
 310 is the fluid flow generated by the attenuation of an acoustic wave in the fluid, classified into
 311 two common types; boundary-driven streaming and bulk-driven streaming (also named Eckart
 312 streaming or quartz wind)⁸⁶.

313 Firstly, the acoustic wave is attenuated by the boundary interaction with the container walls,
 314 resulting in boundary-driven streaming. When an acoustic wave propagates parallel to a solid
 315 boundary, the non-slip boundary creates a high-velocity gradient perpendicular to the solid

316 surface. This creates a steady boundary layer vorticity, called inner boundary streaming (or
 317 Schlichting streaming) which is confined within the thin viscous boundary layer (called shear-
 318 wave layer or Stokes layer) of thickness given by $\delta_v = \sqrt{2\nu/\omega}$, where ν is the kinematic
 319 viscosity, and ω is the angular frequency of the acoustic wave⁷⁵. The strong inner boundary
 320 streaming flow generates counter-rotating streaming vortices within the fluid, called outer
 321 boundary streaming, or Rayleigh streaming⁷⁵. Boundary-driven streaming can appear as (1) a
 322 wave travelling down a waveguide, (2) a standing wave in a resonant chamber, or (3) a wave
 323 scattering off a solid object⁷⁵. For example, for a standing wave, boundary streaming consists
 324 of a vortex-antivortex pair per half wavelength along the direction of acoustic propagation⁸⁶.
 325 It typically occurs in smaller acoustofluidic channels where the characteristic length scale of
 326 the fluid chamber is less than the acoustic wavelength such that,

$$\lambda \gg h \gg \delta_v \quad 7$$

327 where λ is the acoustic wavelength, h is the characteristic length scale of the fluid chamber and
 328 δ_v is the viscous penetration depth.

329 In comparison, bulk-driven streaming (Eckart streaming) is due to the viscous attenuation in
 330 the bulk of the fluid⁸⁶. Stoke's Law of sound attenuation states that the dissipation rate is
 331 proportional to the square of the sound frequency⁸⁶. The acoustic pressure amplitude decreases
 332 with distance from the acoustic source as the wave's amplitude diminishes. This energy loss
 333 causes a steady momentum flow, which generates a fluid jet in the acoustic propagation
 334 direction. Due to the pressure difference, fluid from the chamber's sides replaces the fluid
 335 propelled away by the streaming jet, resulting in a vortex-like flow⁸⁸. It is more pronounced
 336 when the length of the fluid chamber L_E is greater than the acoustic wavelength, and hence
 337 typically occurs in larger devices⁸⁹.

$$L_E \gg \lambda \quad 8$$

338 For BAW systems, the streaming is typically driven by the boundary layer streaming (i.e.,
 339 Schlichting streaming and Rayleigh streaming), whereas streaming fields within SAW systems
 340 are typically driven by the velocity gradient resulting from the attenuation within the fluid (i.e.,
 341 bulk driven streaming)⁹⁰. This is because in a BAW field, the sound propagation is parallel to
 342 the edge of the fluid chamber giving rise to strong boundary effects, whilst these are lessened
 343 in a SAW field in which the sound propagates at an angle to the boundary⁹⁰. For a droplet,
 344 when the SAW contacts the liquid, part of the SAW refracts into the liquid as a longitudinal
 345 wave at an angle known as the Rayleigh angle θ_R ^{27,91}, given by the following equation,

$$\theta_R = \sin^{-1} \frac{v_l}{v_s} \quad 9$$

346 where v_s is the SAW velocity on the surface material, and v_l is the acoustic velocity in the
 347 liquid ⁹². For example, a Rayleigh angle of about 22° is obtained when using a 128° Y-cut
 348 LiNbO₃ piezoelectric substrate at room temperature, where the SAW velocity is about 3,990
 349 m/s, and the speed of sound in water is 1,490 m/s ²⁷. Whereas this value can be as large as 41°
 350 for a ZnO/Al plate SAW based device, as the SAW velocity in the aluminum substrate is about
 351 1,835 m/s ⁹³. The SAW changes modes into a leaky SAW in the fluid that decays exponentially
 352 with distance from the source due to the attenuation by viscosity along its transmission through
 353 the medium ⁹⁴. This decay length is the attenuation length, α^{-1} ⁹⁵:

$$\alpha^{-1} = \frac{\rho_s v_s^2}{f \rho_l v_l} \quad 10$$

354 where ρ_l and ρ_s are the densities of the fluid and the solid, respectively. In contrast, SAW
 355 propagates in the liquid medium along the Rayleigh angle with a distinctly higher attenuation
 356 length, β^{-1} ⁸⁷:

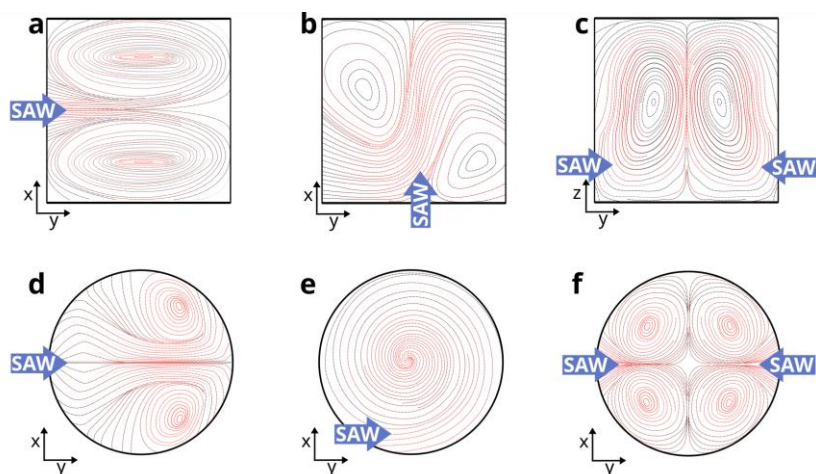
$$\beta^{-1} = \frac{\rho_l v_l^3}{4\pi^2 f^2 (\frac{4}{3}\mu + \mu')} \quad 11$$

357 where μ and μ' are the shear and bulk viscosities of the fluid, respectively.

358 Bulk driven acoustic streaming force is formed in the fluid due to the non-zero and temporally
 359 phase-shifted distribution of the pressure and velocity [50], [51]. Inner boundary streaming
 360 may also arise due to the transmission of shear from the substrate to the fluid, which is confined
 361 in the viscous boundary layer ⁹⁶. Consequently, this could drive outer boundary streaming in
 362 the bulk of the fluid. However, boundary layer streaming is not frequently reported in SAWs
 363 ⁹⁸, and is often negligible compared to bulk streaming if the fluid container size and SAW
 364 attenuation length are much greater than the SAW wavelength ⁹⁹.

365 The SAW induced streaming pattern varies dramatically with the shape of the confined liquid,
 366 the type of IDT configuration used, and the incident position, angle, operating frequency and
 367 power of the SAW ²⁷. Typical SAW streaming patterns that may occur for droplets and
 368 channels are displayed in Figure 4. Figure 4(a-c) and figure 4(d-e) illustrate streaming patterns
 369 in channels and droplets, respectively, demonstrating the varying streaming patterns with
 370 different SAW propagation positions and directions (blue arrow). Figure 4(a) and figure 4(b)

371 show the fluid being driven by the propagating SAWs (coming from the left of the channel,
 372 and the bottom of the channel, respectively), generating two vortex-like flows (top and bottom,
 373 and left and right, respectively). These types of streaming patterns can be used for methods
 374 such as mixing, concentration and rotation as outlined in Section 5.1.3. Figure 4(c) illustrates
 375 an example of SSAW streaming¹⁰⁰ in front view, revealing two vortices. SSAW streaming
 376 applications are discussed in Section 5.2. SAW propagation. Figure 4(d) displays a droplet
 377 streaming pattern, where the SAW propagation enters from the left and forms two vortices.
 378 Figure 4(e) demonstrates streaming when the SAW propagates laterally offset to the droplet,
 379 creating one vortex. Figure 4(f) shows SSAW propagation where four vortices are created. As
 380 discussed in Sections 5.1.1 and 5.1.2, these types of streaming can be used for mixing,
 381 concentration, and pumping.



382
 383 Figure 4. Illustration of two-dimensional fundamental streaming patterns for (a-c) channels and
 384 (d-f) droplets, with different SAW propagation positions as shown by the blue arrows.
 385 (a) and (b) show streaming patterns in the top view, where the SAW propagation enters from
 386 the left, and the bottom, respectively. (c) displays streaming patterns in the front view, where
 387 SAW propagation comes from both the left and the right producing SSAW streaming. SAW
 388 propagation enters the droplets (top view) from (a) the left, (b) laterally offset, and (c) both left
 389 and right (SSAW).

390 The input power applied to an IDT for actuating a droplet can considerably vary the streaming
 391 patterns. At low input powers (in the order of mW), preliminary acoustic streaming on the free
 392 surface is generated, which can be used for vibration, mixing and driving applications. Higher
 393 input power (e.g., above a few watts) leads to a breakup of the stabilizing interface and allows
 394 for techniques such as jetting, atomization or nebulization¹⁰¹.

395 Two types of acoustofluidics have often been defined. The first one is called digital
396 acoustofluidics, which is about sessile droplet under the acoustic field. Droplets act as sample
397 carriers that can be systematically sorted, trapped, mixed, pipetted, and split. They offer many
398 advantages such as low sample consumption, high throughput, flexible manipulation, and
399 elimination of cross-contamination and channel fabrication¹⁰². Parameters including the
400 droplet's shape, volume, contact angle and evaporation determine acoustic streaming patterns
401 that consequently lead to variations in particles' concentration behavior^{101,103}.

402 Another acoustofluidic field is called continuous flow acoustofluidics, e.g., studying the liquid
403 within microchannels or chambers interacting with the acoustic waves. Channels and
404 chambers have advantages as they often contain larger volumes of liquid, incorporate flow, and
405 modify their boundary conditions to allow versatile applications. It is important to note that the
406 channel/chamber boundary has a large impact on its applications. It could consist of different
407 materials (e.g., glass capillary, polydimethylsiloxane (PDMS)), interfaces (e.g., liquid-air,
408 liquid-glass) or geometries (e.g., different dimension/shape tubes or chambers).

409 For both these acoustofluidics, the methods to generate various liquid streaming in a SAW
410 device are crucial. This can be effectively realized using IDTs and this will be introduced and
411 discussed in detail in the next section.

412 **4. Acoustofluidic transduction technologies for acoustic streaming and acoustofluidics**

413 **4.1. Design and manufacture of electrodes**

414 **4.1.1. Design criteria**

415 The key design parameters for the IDTs of SAWs include: center (or resonant) frequency ω ,
416 frequency spectrum, bandwidth, power output density, choice of electrode materials,
417 shape/dimensions (including thickness), positions, substrate isotropic/anisotropic properties,
418 and number of reflective electrodes¹⁰⁴, dispersion, substrate, reflection/transmission functions,
419 electrode types, weighting functions, resistance, electrode length and aperture, electrode phase,
420 electrode positions or delay effect, and wave direction or directivity (e.g., bidirectionality or
421 unidirectionality). The main objectives for improving electrode designs include: (i) increasing
422 the generation efficiency of acoustic waves; (ii) improving spurious signal suppressions; (iii)
423 decreasing insertion loss; and (iv) reducing signal distortion.

424

425 Depending on the different applications (e.g., biosensing or acoustofluidics), the key issues
426 about IDT designs are: ¹⁰⁵

427 (1) **Beam divergence or wave diffraction**⁶³. Due to the beam steering effects, or due to the
428 anisotropic effect of piezoelectric materials, the waves will not propagate in a direction
429 perfectly normal to the wavefront. **Acoustic aperture**¹⁰⁶ (i.e., the overlapping length of
430 electrode) needs to be designed precisely to avoid diffraction of the acoustic beam, and a
431 narrow aperture will cause beam steering and wave spreading when propagating. IDT
432 impedance is also dependent on this aperture. Normally it is recommended to be at least 50
433 times of the wavelengths to achieve an effective function.

434 (2) **Bragg reflection**¹⁰⁶. This is the wave reflections due to the electrode interactions causing
435 in phase scattered waves which have a much stronger reflection. This often happens when the
436 wavelength λ is equal to the periodicity, P . This can be solved by using different electrode
437 designs, such as double electrode (or split electrode) IDTs, which is discussed in the following
438 section.

439 (3) **Numbers of fingers** N ^{63,107}. Increasing this number, the bandwidth will become
440 narrowed, which is useful for achieving a better-quality factor of the resonant peaks. The
441 bandwidth (equals to $2f_o/N$) is also inversely proportional to the number of fingers in the IDTs,
442 and increasing the finger numbers can minimize spurious responses. However, too many finger
443 numbers will cause mass loading and scattering effects from the electrodes (which might
444 degrade the IDT's performance), as well as a much larger size or area of the electrode.

445 (4) **Triple transit signals**¹⁰⁶. This is often caused by the output IDTs producing reflected
446 waves, which are reflected from the opposite IDTs and then reflected second time by the input
447 IDTs. This is also called triple-transit-interference (TTI), or the multiple path effects generated
448 by non-matched output of IDTs as ripples with periodicity in the frequency responses.

449 (5) **Impedance mismatch**^{63,108}. This is one of the key reason for the complexity of surface
450 acoustic wave fields used for microfluidic applications ¹⁰⁸. The impedance matching is critical,
451 otherwise, much of the acoustic wave energy will be dissipated within the IDTs. Electrical
452 dissipation in other forms should be avoided, such as electrical shielding and conductive short
453 connections. This can be solved by using a matching network or adjusting the IDT designs.

454 (6) **Bidirectional effect**⁶³. A straight conventional IDT has waves propagating in two
455 directions; thus, the wave energy will be wasted if one of the wave directions is not used. This
456 can be resolved using different designs such as single-phase unidirectional transducer which is
457 discussed later.

458 (7) **Heating effect**⁵⁷. The propagating wave produces atomic vibrations that causes heating
459 effects. Heating effects can be increased by defects, degradation, or malfunction of the device
460 causing internal dissipations of energy, or from reflections from the power supply.

461

462 In the following sections, we will separate the IDT topics into transducer materials, fabrication
463 techniques, and advances in IDT for acoustic streaming and acoustofluidics applications.

464

465 **4.1.2. Transducer materials**

466 IDT's materials influence the performance and electromechanical coupling coefficient of the
467 SAW devices^{109–111}. The IDTs are generally required to have a low mass to minimize wave
468 damping. They also need to have a high acoustic impedance to confine the acoustic waves
469 within the piezoelectric layer, and have a high conductivity to minimize the series resistance in
470 the transmission of the excitation signals. The different electrode materials have been discussed
471 by Fu et al.⁵⁷, based on their acoustic impedances ($Z = \rho \cdot v$, in which ρ and v are the density
472 of material and velocity of the waves) and ξ is resistivity of the materials.

473

474 For fabricating SAW devices, Al and Au/Cr (or Au/Ti) are the most frequently used electrode
475 materials. Al is the 3rd most abundant element on earth (after O and Si). Al electrode has its
476 advantages of low cost, a low resistivity, and low acoustic impedance, as well as a high Q factor
477 used as SAW IDTs, thus it is often used for delay lines and transversal filters. However, it has
478 some critical issues such as low mechanical strength, low melting points and poor electro-
479 corrosion resistance. Normally it requires enough thickness (commonly 100 to 200 nm) to
480 present a low electrical resistance but should not be too thick to cause problem with mass
481 loading effect and significantly increased acoustic impedance. Au electrodes have its
482 advantages at high power or with liquid, or in corrosive environments. However, at higher
483 frequency, gold IDTs show large mechanical losses, relatively large mass loading and
484 reflection, whereas aluminum IDTs show high reflection coefficients and high Q factors at
485 higher frequencies¹¹².

486

487 Some conducting and transparent oxides, such as aluminum doped zinc oxide and indium tin
488 oxide, have also been applied as electrode materials for transparent SAW devices^{113,114}.
489 Graphene^{115,116} and its derivatives, with their theoretically high conductivity and being an
490 extremely thin and light material which would cause insignificant mass loading¹¹⁷, has been

491 applied as the IDTs of SAW devices ^{118,119}. Multilayer graphene with a sheet resistance of a
492 few tens of Ω/sq could improve the transmission properties ¹²⁰.

493

494 When choosing the substrate materials to place the IDTs on, various factors should be
495 considered, including cost, temperature dependence, attenuation, and propagation velocity. For
496 example, the anisotropic properties of the substrates will cause significant direction-dependent
497 electromechanical coupling effects, therefore, their orientation and cut will determine the
498 efficiency of the device's electrical energy transduction from the SAWs. Anisotropy effect of
499 the substrate will affect which type of waves are generated: e.g., SH-SAW, leaky SAW, or
500 pseudo-SAW ²⁷. The anisotropic wave propagation velocities within the planes are critical
501 issues for effective IDT layout designs along various crystal-cut directions ¹²¹.

502

503 LiNbO_3 is commonly used in SAW fabrication for acoustofluidics due to its outstanding
504 electromechanical coupling coefficient ¹⁰⁷. However, due to LiNbO_3 's rigidity, brittleness, and
505 anisotropic nature, many other substrates have also been explored. Piezoelectric thin films
506 including zinc oxide (ZnO) ^{122–124} and aluminum nitride (AlN) can be deposited onto various
507 substrates such as silicon (Si), glass, ceramics, diamond, quartz, glass, and more recently also
508 polymer, metallic foils and bendable glass/silicon for making flexible devices ^{57,123}. Using
509 piezoelectric films would allow for fabrication of integrated, disposable, or bendable devices.
510 Due to the isotropic nature of thin film materials deposited onto a planar substrate, flexible
511 designs of electrodes or IDTs, such as focused, curved, circular/annular, or randomly shaped
512 patterns are readily achievable on thin film acoustic wave devices ⁵⁷. Additionally, bulk
513 ceramic substrate such as LiNbO_3 has a low thermal conductivity and poor fracture toughness
514 which becomes a challenge when a high power is needed. Thin films such as aluminum nitride
515 or gallium nitride (GaN) could be a novel piezoelectric films that, although piezoelectric
516 performance is compromised, allow for higher input power and superior thermal stability ^{125,126}.

517

518

4.1.3. Fabrication techniques

519 Cleanroom manufacturing techniques involve photolithography, evaporation and sputtering,
520 lift off or etching. These techniques allow for the fabrication of high efficiency, small-scale,
521 precise, and reproducible IDTs. Standard patterning techniques are either subtractive or
522 additive patterning, e.g., one method involving etching and the other lift-off, respectively. The
523 main steps for subtractive patterning are deposition, lithography, and etching. Firstly, the wafer

524 is cleaned before any IDE material is deposited to ensure the metal adheres successfully.
525 Deposition can be done by either sputtering, thermal evaporation, or chemical vapor deposition.
526 Lithography is performed by patterning photoresist using ultraviolet light exposure through a
527 mask to create a positive image of the IDEs after developing. Wet or dry etching can be used
528 to etch the IDE material. Lastly, the photoresist is removed to complete the process. The
529 additive method involves using lithography to pattern photoresist such that it creates a negative
530 image of IDTs after being developed. The IDE material is deposited on top of the patterned
531 photoresist. Then, the photoresist and the excess IDE material is removed using a lift-off
532 process.

533
534 Apart from the above conventional photolithography processes, new techniques such as
535 electron beam lithography, focused ion beam milling, or nanoimprinting, have been used for
536 making sub-micron wavelengths, thus super-high frequency SAW devices can be obtained. For
537 example, SAW devices with super-high frequencies (from 20 to 44 GHz) based on LiNbO₃,
538 ZnO/SiO₂/Si, or LiNbO₃/SiO₂/SiC heterostructures were reported using an e-beam lithography
539 method ^{127–129}.

540
541 Clean room technique however can be expensive. Brittle piezoelectric substrates such as
542 LiNbO₃ are often used for making the IDTs. Not only can it be problematic to make
543 modifications, but also it is difficult to repair any mistakes or damages once the patterns have
544 been processed. To overcome this, IDEs can be manufactured separately from the piezoelectric
545 material, and then pressed onto the piezoelectric substrates to generate SAWs, for example,
546 using a printed circuit board (PCB), which is especially useful for prototyping. This method
547 consists of mechanically clamping electrodes made using PCB or even flexible PCB with a
548 piezoelectric substrate ^{130–132}, thus the waves can be generated by simply applying RF
549 frequency to the pressed IDEs on the piezoelectric substrates.

550
551 Additional methods of creating electrodes have also been explored, such as by pouring low-
552 melting-point metal into a mold by PDMS ¹³³, stacking aluminum foil strings onto substrate ¹³⁴
553 and using superstrates on conventional SAW devices to allow their reusages for different
554 applications ¹³⁵. 3D printing can be used to produce various shapes of electrodes and electrode
555 arrays with specially designed reflectivity and directionally (e.g.,
556 bidirectionality/unidirectionality) and varied frequency spectra, although the IDTs' resolution
557 might not be as good as those from lithography ones.

558 **4.2. Advances of Interdigital Transducers**

559 **4.2.1. Conventional IDT structures**

560 As mentioned in Section 4.1, the **standard bidirectional IDTs** have a simple design (as shown
561 in Figure 5(a)), which has two electrode fingers, bus bars and electrode pad. However, it has
562 issues such as internally mechanical edge reflections and loss of wave energy at two sides
563 therefore half of the energy could be wasted in one direction. Various IDT designs have been
564 studied to solve the critical issues, including straight or curved (focused or plane waves) types
565 of IDTs, standing waves or propagating waves, and aligned or shifted waves. It should be noted
566 that some of these IDTs are designed for sensing purposes, but not best for acoustic streaming
567 applications.

568

569 (1) **Split IDTs (Figure 5(b))**. This is used to reflect some of the waves, thus reduce
570 reflections. It is also used to minimize the spurious response due to the finger reflections.

571

572 (2) **Single phase unidirectional transducer (SPUDTs, Figure 5(c))**. SPUDTs have been
573 commonly used to reflect or cancel regenerated waves using the internally tuned reflectors
574 within the IDTs to form unidirectional SAW propagations from the IDTs. It can minimize the
575 triple transmission effect (TTE), reduce the noise/insertion loss, and reduce the passband
576 ripples.^{136,137} There are different designs for the SPUDTs. (1) Split finger pair by simply using
577 $1/16 \lambda$, in which all the gaps are equal to $1/8 \lambda$. (2) Fixed split finger pair and varied widths to
578 obtain a required directivity, e.g., different-width split finger SPUDT¹³⁸, in which the gap
579 width between sections of opposite directivities as $1/16 \lambda$ and the distance between the two
580 adjacent reflection center is $1/4 \lambda$. (3) Triple electrode section SPUDT, in which all the gaps and
581 fingers are designed as $3\lambda/8$, which will generate a third harmonic response stronger than its
582 fundamental response. (4) Special designs such as with finger widths of $1/5$, $2/5$, $1/5$, and $1/5$
583 λ . The problems for these SPUDTs are that the small electrodes size limits the fabrication of
584 super high frequency devices. There is a reduction in total SAW energy meaning that the SAW
585 generation efficiency is much lower, and its insertion loss is higher.

586

587 (3) **Distributed acoustic reflecting transducer (DART, Figure 5(d))**. This includes a
588 sequence of identical cells with a length equal to wavelength λ , and each cell has two electrodes
589 width of $1/8 \lambda$, and one electrode of width $1/4 \lambda$, the inter-electrode space is $1/8 \lambda$. Variable
590 reflection can be achieved to cancel the net reflection and transmission effects. By segmenting

591 the reflecting electrodes, a variable reflectivity can be achieved, thus providing design
592 flexibility. They might be beneficial for SAW microfluidics and sensors as it not only improves
593 the performance, but also maintains the SAW devices at the best operating conditions.

594

595 **(4) Floating electrode unidirectional transducers (FEUDTs, Figure 5(e)).** One (or more)
596 electrodes is/are not connected to others and are floating. In the FEUDTs, the shorted or open
597 electrode configuration changes the transductor/reflector interaction and promote forward
598 transmissions.

599

600 **(5) Apodised IDTs (Figure 5(f)).** This is achieved by varying or setting the non-uniform
601 beam profiles for weighting a SAW transducer. In this design, the IDTs have different lengths
602 and different positions, and they generate impulse response/pre-patterned pulse waves. The
603 overlaps of the electrodes are varied along the length of the transducer, which can generate a
604 specific frequency response. In apodization technique, the top electrode is designed with non-
605 parallel edges which increases the resonant path and leads to more attenuated modes, thus
606 degrading the strength of spurious lateral modes. This pattern is generally used for wave
607 shaping and manipulation of frequency response of the IDTs. It can also be used for minimizing
608 heating effects, and avoiding bulk wave interferences, diffraction, and IDT end-effects, or
609 optimizing the output signal profile.

610

611 **(6) Focused or curved IDTs (FIDT, Figure 5(g)).** These IDTs can generate strong and
612 focused acoustic force or energy, which can be used to concentrate the acoustic energy to a
613 focal point. It has been utilized for improving pumping and mixing efficiency in
614 acoustofluidics, and for enhancing sensitivity and resolution in sensing applications. The
615 curved IDTs have been utilized for enhanced pumping and mixing functions with a strong
616 concentration effect.¹³⁹ However, due to the anisotropic nature of many crystal cuts of bulk
617 piezoelectric materials, it is recommended to modify the IDTs into a concentric elliptic shape,
618 whose curvature might be smaller than that of the wave surface ^{139,140}.

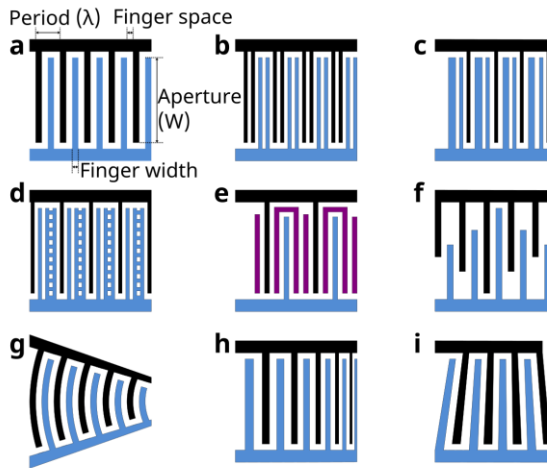
619

620 **(7) Chirped IDTs or dispersive delay lines (Figure 5(h)).** These are achieved by varying
621 the width and frequency of IDTs to control wave modes and reflectivity, to linearly modulate
622 the wave pitch or frequency. The bandwidth can be relatively large, and the frequency can be
623 changed gradually by decreasing the electrode spacing and increasing the electrode spacing. It
624 can be designed into an expander (from large width to smaller width) or a compressor (from

625 small width to larger width). Chirped IDTs are useful for manipulating droplets in different
 626 directions and for focused acoustic energy propagation. They are able to manipulate or change
 627 the moving direction of a droplet by changing and tuning the operating frequency continuously,
 628 thus used for manipulation of single microparticles, cells and organisms ^{141–143}.

629
 630 **(8) Slanted finger IDTs or tapered or tilted IDTs (SF-IDT, Figure 5(i)).** ^{144,145} They have
 631 varied frequencies in the IDT section by changing the electrode's periodicity. They have broad
 632 bandwidths, which can change the moving direction of a droplet by changing the operating
 633 frequency continuously ^{27,146,147}.

634



635 Figure 5. Conventional IDT designs. **(a)** Standard bidirectional IDTs **(b)** Split IDTs **(c)** Single
 636 phase unidirectional transducer (SPUDT) **(d)** Distributed acoustic reflecting transducer
 637 (DART) **(e)** Floating electrode unidirectional transducer (FEUdT) **(f)** Apodised IDT **(g)**
 638 Focused or curved IDT **(h)** Chirped IDT or dispersive delay lines **(i)** Slanted finger IDT or
 639 tapered or tilted IDTs (SF-IDT).
 640

641 **4.2.2. Unconventional IDT structures**

643 Apart from the above commonly used IDT structures, there are many different types of
 644 uncommonly used IDT patterns.

645
 646 **(1) Circular or annular IDT (Figure 6(a)).** Focused IDTs can be extended to create circular
 647 IDTs ^{148,149}. Circular IDTs have a large focused acoustic force or energy, and have been utilized
 648 for improved pumping, mixing, and jetting of droplets. However, they have the same problem

649 as FIDTs of the anisotropic properties of the substrates of 128°Y LiNbO₃ is, e.g., there is
650 anisotropic effect for the velocities of waves along different directions. This can be improved
651 by designing a slowness curve deviating from the circular shape, or using a concentric elliptic
652 shape, which causes the beam direction no longer to parallel to the propagation direction¹⁵⁰.
653 Also, for these circular IDT devices, the angle dependent coupling coefficient in a device of
654 128°Y LiNbO₃ is significant. Therefore, the key issue for such a circular IDT device is to
655 achieve uniform waves from different directions. As we mentioned before, for piezoelectric
656 thin film based SAW devices, such an issue is often insignificant due to the isotropic wave
657 propagation on the planar surfaces of thin film SAW devices.

658

659 **(2) Dual wavelength IDTs.** Two different wavelength designs in one IDT can be applied,
660 which can generate two different SAWs after applying different frequencies. Although both
661 IDT designs consist of the same aperture, the dual-wavelength SAWs can be generated
662 separately or simultaneously, which can be spatially superimposed along the propagating path
663 within the microchamber or the microfluidic channel. The generated complex acoustic pressure
664 field can be applied to separate or mix particles of different sizes.

665

666 **(3) Spiral IDT designs^{151,152} or anisotropic swirling SAWs** (see Figure 6(b) to 6(d)). These
667 can be used to tailor acoustical vortices, or for 3-D particle manipulation and vorticity control.
668 Spiral electrode designs can generate in-plane torsional vibrations. Spiral IDTs can be difficult
669 to design when consider the anisotropic wave velocity in different plans and directions for
670 many bulk piezoelectric crystals. Three types of design structures are proposed. (1) Swirling
671 IDT designs (Figure 6(b)), which can generate varied acoustic wave fields by simply changing
672 the applied signals; (2) Constant electrode spiral angle (Figure 6(c)), which provides a uniform
673 spiral angle for electric field but varied intensity^{13,151}; (3) Constant pitch (distance) between
674 adjacent electrodes (Figure 6(d)), which can provide a uniform intensity of electrode fields but
675 various spiral angles, hence this design has a better in-plane torsional displacement and
676 vibrations than the previous one^{153,154}. The last one is also called Ring waveguide resonator
677 IDTs¹⁵⁵, which was reported to have a high-quality factor due to its regularity of electrode
678 structure, and the electrical admittance does not have any sidelobes. Thus, it can be suitable for
679 sensor applications. This design has a “slow” electrode region with a “fast” surrounding region,
680 with the acoustic fields concentrated in the electrode region. Additionally, circular slanted
681 finger IDTs with angularly varying finger widths and spacing can introduce frequency-

682 multiplexing ¹⁵⁶. Practically, these complex wave fields generated using spiral SAW acoustical
683 vortices can be used for particle tweezing, liquid twisting and swirling on a single functional
684 platform. This design can generate focused waves which are varied constantly by adjusting
685 different focusing points in arbitrary positions ^{157,158}. This has been used to demonstrate for a
686 variety of biological applications, including droplet transportation separation, fusion, and
687 nebulization ^{157,158}.

688

689 **(4) Holographic IDTs (Figure 6(e))** ^{159,160}. These can be used to produce waves by
690 designing specially metallic electrodes with equi-phase lines of the targeted wavefield at the
691 surface of a piezoelectric substrate, showing laterally focused (cylindrical) and 3D focused
692 (spherical) acoustical vortices. The SAW based holographic IDTs ^{159,160} have advantages of (i)
693 high working frequency, allowing resolutions down to micrometric scales; (ii) easy fabrication
694 with standard lithography techniques; and (iii) simple integration in a standard microscope
695 since they are flat, transparent and miniaturized ^{159,160}.

696

697 **(5) Ball shaped IDTs (Figure 6(f))**. The wave propagates around the equator of a large
698 sphere in multiple roundtrips, where the number of the SAW circulations around the ball equals
699 the SAW's propagation length. This can be used as a good sensor or acoustofluidic device on
700 a ball-shaped device. Due to the collimation of the SAWs, the energy loss from diffraction is
701 avoided. Therefore this is beneficial for sensors as the SAW propagation path can be much
702 longer and the sensitivity could be higher ¹⁶¹.

703

704 **(6) Inter-digitated IDT (IIDT, Figure 6(g))**. It uses the interweaved input and output
705 transducers to eliminate the inner transducer's bidirectional insertion losses and suppress the
706 sidelobes of the spectrum.

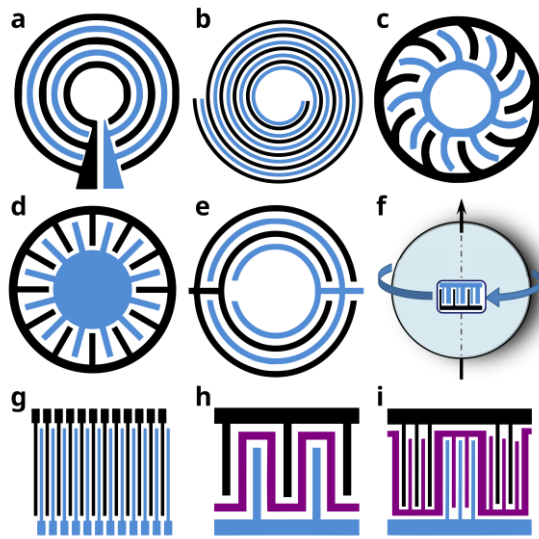
707

708 **(7) Tunable IDT (Figure 6(h) and multiphase IDTs (Figure 6(i))**. Conventional IDTs with
709 fixed pitch comb electrodes can be replaced by a series of densely distributed electrodes to
710 form a tunable IDT ¹⁶². Different wavelengths can be formed by connecting them in various
711 configurations, without changing the electrode layout. Other tunable IDTs could be consisted
712 of several IDTs arranged in an in-line configuration with different center frequencies and
713 bandwidths ¹⁶³.

714

715 **(8) Embedded IDTs**. IDTs are normally made on top of the piezoelectric substrates, which

716 have potential problems of reflection and scattering effects of these IDTs. One potential method
 717 to solve this is to use the IDTs fingers embedded inside the substrates ¹⁶⁴. However, this needs
 718 extra fabrication steps such as etching into substrates and post-polishing or other procedures
 719 ¹⁶⁴. This type of design is important for focused IDTs, which can minimize the finger grating
 720 effects on the angular dependence of the phase velocity ¹⁶⁵. For thin film-based SAW devices,
 721 this becomes easier as the IDTs can be deposited firstly onto the surface, or filling in the
 722 grooves to eliminate technological imperfections for burying electrodes ^{166,167}.
 723



724
 725 Figure 6. Unconventional IDT designs. (a) Circular or annular IDT (b) Swirling IDT (c)
 726 Electrode spiral angle IDT (d) Ring waveguide resonator IDT (e) Holographic IDT (f) Ball
 727 shaped IDT (g) Inter-digitated IDT (IIDT) (h) Tunable IDT (i) Multiphase IDT.
 728

729 **4.2.3. IDTs embedded into multi-layer structures**

730
 731 As explained before, due to the isotropic nature of thin film materials deposited onto a planar
 732 substrate, flexible designs of electrodes or IDTs, such as focused, curved, circular/annular, or
 733 randomly shaped patterns, are readily achievable on thin-film acoustic wave devices ¹²¹. Due
 734 to the thin film deposition process, the IDTs do not always need to be on top of the piezoelectric
 735 materials. For example, a “liquid needle” has been the early demonstration in which a circular
 736 self-focused bulk wave acoustic transducer with circular IDTs (on both top and bottom of the
 737 thin-film piezoelectric material) are used to generate a focused acoustic wave and produce a
 738 needle-shape liquid column on the free liquid surface ^{168–170}. As different layers have been used

739 in thin-film acoustic wave devices to improve temperature stability, phase velocity and
740 electromechanical coupling coefficient, the position of the IDTs can be designed in different
741 ways ¹⁷¹. As explained in Ref. ⁵⁷, there are variations of such designs. (1) the IDTs can be on
742 top of the substrate, and either the substrate or the intermediate layer must be piezoelectric; (2)
743 the IDTs can be on top of the intermediate layer, and either the intermediate or the top layer
744 must be piezoelectric; (3) the IDTs can be on the top layer, and in this case, the top layer must
745 be piezoelectric to excite the acoustic waves. (4) two same types of IDTs on both intermediate
746 and top layers to enhance the acoustic wave generation; (5) the IDTs can be located on top of
747 the piezoelectric film with a short-circuiting plane underneath; (6) The IDTs can be located
748 under the piezoelectric layer with a short-circuiting plane on top.

749

750 The IDTs can be either on the piezoelectric layer or beneath the piezoelectric layer to generate
751 the acoustic waves. Adding a piezoelectric layer or dielectric layer with a high permittivity
752 above the IDTs increases the electromechanical coupling, allowing the fabrication of devices
753 with reduced insertion loss or smaller size ¹⁷². A hard insulating top layer can shield the IDTs
754 of the piezoelectric film or sub-layers and the substrate from harsh environments or liquids,
755 thus enhancing the long-term stability of the devices ¹⁷³.

756

757 In brief, IDT designs and fabrications are critical in generating streaming patterns using SAW
758 devices. Different IDT designs and configurations can generate a variety of sensing functions
759 and distinct streaming patterns. Adjusting the IDT design, configuration, and input parameters
760 (such as applied power, amplitude and frequency) makes it possible to improve sensitivity, or
761 manipulate the acoustic streaming patterns for the desired applications, as discussed in the next
762 section.

763 **5. Acoustofluidic streaming applications using transducer designs**

764 SAW devices are increasingly used in biomedical applications as they are simple but meet most
765 of point-of-care requirements. Numerous actuation techniques with different applications can
766 be achieved depending on factors such as the boundary conditions (sessile droplet, open or
767 closed channel or chamber), static liquid or flowing liquid, the power delivered to the device
768 (ranging from mWatts to Watts) and the IDT designs (for example conventional IDT, FIDT).
769 The following sections will discuss various applications based on travelling SAWs (TSAWs)
770 and standing SAW (SSAWs) based acoustic streaming and acoustofluidics.

771 **5.1. TSAWs based streaming and acoustofluidics**

772 TSAWs generates physical phenomena of streaming driven particle behavior and the drifting
 773 of particles due to acoustic radiation forces, under propagating acoustic waves into the substrate
 774 and liquid ¹⁷⁴. TSAWs typically propagate in one direction ²⁷, trigger mixing through streaming
 775 vortices, and produce shear stress on cells within a microchannel or microchamber. TSAWs
 776 have been applied more commonly to cause mixing, pumping liquids, or translocation of
 777 droplets, generating jetting and nebulization. **Text for applications Figure XXX.**

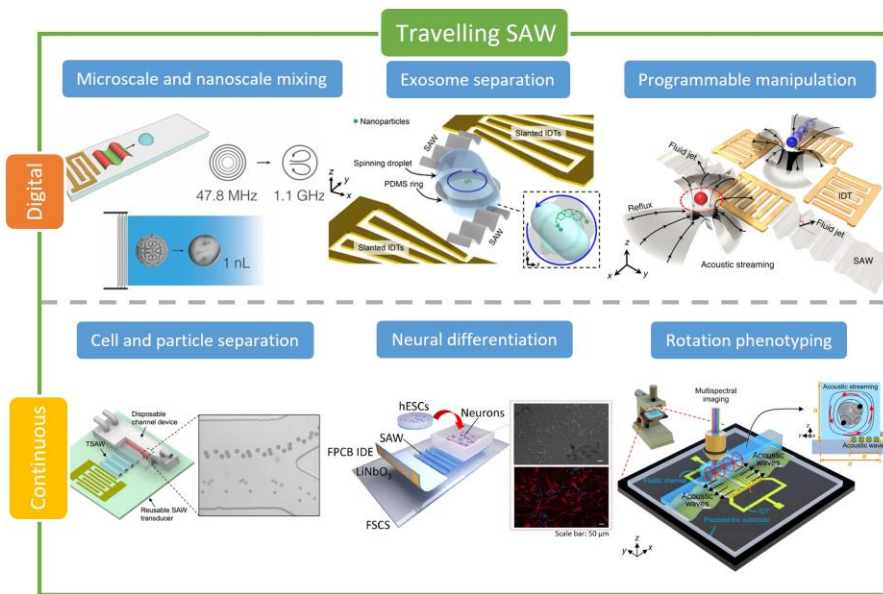


Figure X. Examples of real-life medical applications of TSAW streaming, for both digital and continuous acoustofluidics. **TSAW digital:** (left) A gigahertz SAW device for nanoscale droplet mixing. Reproduced with permission.¹⁷⁵ Copyright 2014, Wiley. (middle) A SAW device enabling droplet spinning and induced vortex streaming for concentration and separation of exosomes. Reproduced with permission.¹⁴ Copyright 2021, Science. (right) Four IDTs (one unit/pixel) for programmable digital acoustofluidics. Reproduced with permission.¹⁷⁶ Copyright 2018, Nature Communications. **TSAW continuous:** (left) A detachable device with a reusable IDT and a disposable microchannel, for size selective PS microparticle separation. Reproduced with permission.¹⁷⁷ Copyright 2016, The American Chemical Society. (middle) A detachable FPCB device for neural differentiation of human embryonic stem cells. Reproduced with permission.¹⁷⁸ Copyright 2022, Elsevier. (right) An acoustofluidic chip for enabling rotational manipulation of zebrafish larvae for contactless morphological phenotyping. Reproduced with permission.³⁶ Copyright 2021, Nature Communications.

778

779 **5.1.1. Mixing, concentration, and splitting of sessile droplets in digital acoustofluidics**

780 **Mixing**

781 Microfluidic applications involving sessile droplets are hampered by diffusion-limited mixing
782 due to their small dimensions. SAW devices can be used as a mixer to overcome this issue. It
783 is effective to use TSAW induced streaming to mix sessile droplets¹⁷⁹ and nanoliter order
784 droplets¹⁷⁵ by placing a singular straight IDT directly opposite to it (Figure 7(a)). This droplet
785 mixing can be used in applications such as size tunable nanoparticle fabrication using droplet
786 fusion¹⁸⁰, or particle sampling device for the collection of airborne micro-particles¹⁸¹. TSAW
787 streaming can be utilized for cleaning biological sensors, by removing fouling caused by
788 nonspecific binding proteins on the surface, to allow more accurate determination and reuse of
789 the devices¹⁸². The TSAW induced mixing can be combined with a metal enhanced
790 fluorescence¹⁸³ or surface plasmon resonance system³⁵, to improve mass transfer for
791 biosensing capabilities. Moreover, combining a singular straight IDT device and electrowetting
792 on dielectric (EWOD) can precisely guide and position microdroplets, for example, EWOD
793 assisted SAW particle streaming and concentration, SAW assisted EWOD splitting, and
794 EWOD assisted SH-SAW sensing¹⁸⁴. The addition of an electric field can also increase the
795 streaming velocity in a droplet by a factor of about 2-3 and change the flow pattern compared
796 to that without the electric field¹⁸⁵.

797 As a result of the mixing and hence inhomogeneously acoustic streaming in a droplet, cells
798 within the liquid droplet will experience a shear force¹⁸⁶. This shear force may interact with
799 cells through biological pathways, including the cell membrane, extracellular matrix, and
800 cytoskeleton, instead of simply displacing cells¹⁸⁷. The shear forces can induce action
801 potentials¹⁸⁸ and calcium responses¹⁸⁹ in neurons, and affect cell adhesion and survival rate
802 in cell culture^{187,190,191}. For example, an actuated straight IDT can result in the collision
803 between cells and magnetic Ag-nanowires in a cell droplet, leading to 97% lysis efficiency
804 with a power of just 1 Watt¹⁹². Similarly, by using a 17.1 MHz electrode of width controlled
805 SPUDT to ensure that the acoustic energy is directed solely in the forward direction, HEK 293
806 cells can be effectively detached and sorted from A7r5 cells based on differences in adhesion
807 strength within minutes¹⁹³. In Ref.¹⁹⁰, an FIDT has been used for characterization of adhesive
808 properties of red blood cells (RBCs) in a 9 μm droplet within just 30 s. This method can be
809 used to perform rapid diagnostics and disease monitoring in a small fluid volume, which is
810 attractive as it requires no external rising agents such as trypsin, typically used for cell
811 dissociation from the solid substrate.

812 When mixing particles with a high rate of mass transfer, it is necessary to consider the size of
813 the particles. Large particles are affected mainly by radiation forces, while small particles will
814 flow along with the vortices of acoustic streaming ¹⁹⁴. The uses of both the acoustic radiation
815 force and the acoustic streaming generated by a 20 MHz straight IDT can be used
816 simultaneously concentrate and separate two microparticle sizes (e.g., 6 and 31 μm
817 polystyrene-PS particles ¹⁹⁵) in a sessile droplet. The smaller particles are dispersed in the bulk
818 of the droplet due to drag force, whereas the larger particles are concentrated on the free surface
819 of the droplet due to the radiation force. This demonstrates the existence of frequency-
820 dependent crossover particle size that can affect species partitioning.

821 **Concentration**

822 The key for the concentration of an object within a droplet is the asymmetric distribution of
823 SAW radiation along the width of the droplet. It is possible to achieve this by different schemes
824 of symmetry breaking of SAW propagation to generate an azimuthal liquid recirculation as
825 shown in Figure 7(b-d). The concentration effect can also be generated by placing the droplet
826 along one side of the IDTs with a reflector (Figure 7(b)). Shielding off one half of an open
827 reflector using a damp material allows control over the SAW that is reflected (Figure 7(c))¹⁹⁶.
828 Additionally, cutting the edge opposite to the input IDT at an angle to the propagation axis can
829 effectively reflect the SAW radiation at an angle, resulting in symmetry breaking (Figure 7(d)).
830 Using this method, it is possible to efficiently concentrate micrometer sized objects, such as
831 PS microspheres (1 to 45 μm) and living yeast cells (10-20 μm) using low powers from 120 to
832 510 mW ¹⁹⁶. The concentration of particles can increase analyte detection sensitivity and
833 overcomes the diffusion limitation without particle damage, allowing a range of sensor
834 technologies.

835 Four distinct regimes (R1-R4) of particle concentration that are mostly available at higher
836 frequencies can be produced by placing a singular straight IDT offset to a droplet as shown in
837 Figure 7(e)¹². In R1, the particles are concentrated at the center of the droplet in the form of a
838 bead. In R2, the particles are around the periphery of the droplet in the form of a ring. In R3,
839 at the side of the droplet, an isolated island is formed. Finally in R4, a smaller ring is formed
840 at the center of the droplet ¹². The different regimes are due to the various forces generated
841 (acoustic streaming-based drag force, travelling or standing SAW-based acoustic radiation
842 force and the centrifugal force)¹². The regimes of particle's aggregation depend on the κ -factor
843 (defined by $\kappa = \pi d_p / \lambda_f$, where d_p is the diameter of the particle and λ_f is the wavelength of the

844 acoustic wave in the fluid), the acoustic wavefield (travelling or standing), the acoustic waves
845 attenuation length (x_s) and droplet volume where r_d is the radius of the droplet. The attenuation
846 of the sound wave in the fluid (x_f) is negligible as it attenuates at a much longer distance, and
847 hence the focus is on the rapidly attenuating SAW wave¹².

848 A focused SAW can generate concentric surface acoustic waves which have high intensity,
849 high beam width compression ratio and small localized area. Hence, the focused SAWs can be
850 used to enhance streaming force up to 480% of the conventional SAWs¹⁹⁷. Circular and
851 focused SPUDT have an increased wave intensity and asymmetry of the waves, and therefore
852 they can also be effectively used to concentrate particles, which is one order of magnitude
853 faster than straight SPUDT and several orders of magnitude faster than the conventional
854 microscale devices¹⁹⁸. When comparing the different SPUDT devices, the circular SPUDT has
855 been shown effective at a given input power since it can generate the largest azimuthal velocity
856 gradient within the fluid to drive particle shear migration. On the other hand, the focused
857 SPUDT (Figure 7(f)) can generate the highest mixing intensity due to the focused SAW
858 radiation that substantially enhances acoustic streaming in the fluid¹⁹⁹.

859 **Separation**

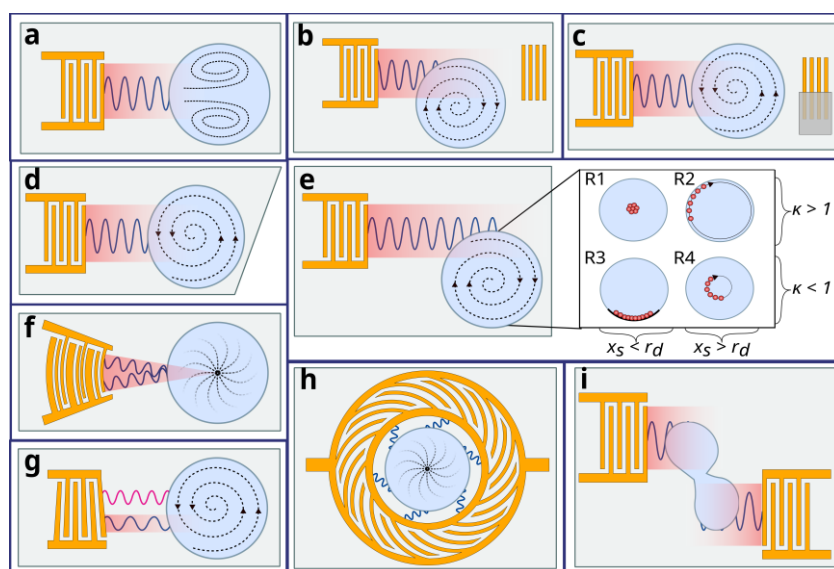
860 Another method for asymmetric actuation is to use an SF-IDT, which causes a circular rotation
861 motion inducing acoustic streaming of the cells in the droplet for their separation (Figure 7(g)).
862 Such actuation has been reported to separate malaria-infected RBC at the periphery of the
863 droplet, based on the difference in cells' densities using SAWs²⁰⁰. Most acoustofluidic systems
864 that aim for nanoscale manipulation are difficult to achieve this function due to the insufficient
865 acoustic radiation force and abundance of acoustic streaming to control nanosized particles.
866 Nonetheless, this acoustic centrifuge motion can overcome such limitations. Gu *et al.*¹⁴
867 reported the use a pair of SF-IDTs and a circular PDMS containment ring to define the droplets
868 equilibrium shape. The SF-IDTs allows various frequencies to be applied, generating SAWs at
869 different positions on the piezoelectric substrate, and therefore spin can be created on altered
870 size droplets, so long as the wave enters the droplet from a position which has a slight bias
871 from its center line. By adding two spinning droplets with a microchannel for particle passage,
872 differential phenomena including concentration and separation can occur. Using this method,
873 exosome separation and transport can be achieved, where the right-side droplet contained a
874 greater distribution of the smaller nanoparticles and the left-side droplet with the larger

875 nanoparticles¹⁴. This configuration has also been used to perform both drug loading and
 876 exosome encapsulation²⁰¹.

877 An omnidirectional spiral SAW that uses a 152° Y-rotated, can rapidly rotate a microliter
 878 droplet for multi-size particles for their separations and extractions, as illustrated in Figure 7(h).
 879 The rapid rotation is realized through the axisymmetric omnidirectional spiral SAW.
 880 Separation and extraction of RBCs and platelets within mouse blood can be achieved with 83%
 881 and 97% purity, respectively¹³. Unlike previous configurations to separate particles, this
 882 method can successfully extract target particles for bio-sampling functions.

883 Splitting

884 Instead of particle concentration and separation of objects in a droplet, SAW can aid in merging
 885 and splitting of droplets as illustrated in Figure 7(i). Two single phase transducer (SPTs)²⁰²
 886 can realize this separation function. An SF-IDT²⁰³ was also used for separation of water from
 887 an oil/water mixed drop. A pair of IDTs which were laterally offset modulated SAWs enabled
 888 droplets with volumes of 0.5 to 6 μl to be symmetrically divided into two equal size droplets
 889²⁰⁴.



890
 891 Figure 7. Droplet mixing, concentration and splitting of sessile droplets in digital
 892 acoustofluidics IDT device examples. (a) Singular straight IDT directly opposite droplet for
 893 TSAW mixing. (b-d) Schemes of symmetry breaking for rotational motion such as using a (b)
 894 reflector, (c) shielding off one half of an open reflector, (d) or cutting the substrate edge. (e)

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895 Singular offset IDT with 4 regimes of concentration (R1) particles are concentrated at the
896 center of the droplet, (R2) around the periphery of the droplet, (R3) at the side of the droplet,
897 and (R4) close to the center of the droplet. (f) Focused SPUDT with focused SAW around
898 center of the droplet. (g) SF-IDT with SAW generated at defined position asymmetrically with
899 respect to droplet for rotation motion. (h) Omnidirectional Spiral IDT with circular streamlines
900 in the droplet¹³ (i) Pair of laterally offset straight IDTs for droplet splitting.

901 **5.1.2. Pumping, jetting, nebulization/atomization, and droplet generation in digital** 902 **acoustofluidics**

903 **Transportation**

904 Discrete liquid pumping (i.e., droplet translation) can be achieved by applying SAW to a sessile
905 droplet. If the applied SAW power is higher than a limit, the internal streaming leads to a
906 deformation of the droplet, which eventually translates the droplet in the direction of the SAW
907 propagation. The applied SAW power overcomes the forces stimulated by contact line pinning
908 and contact angle hysteresis. For microfluidic applications, pumping of a sessile droplet in the
909 scale of microliter without evaporation is challenging, hence low powers need to be used, or
910 the droplet has to be encapsulated in oil²⁰⁵. Other methods to avoid problems of droplet
911 evaporation and temperature for biological activity can be accomplished by aid of a steel ball
912 medium²⁰⁶, avoiding direct radiation of SAWs on the piezoelectric substrate using a superstrate
913 idea, or by converting the microdroplets into a continuous flow²⁰⁷.

914 When using a 20 MHz straight IDT SAW device (Figure 8(a)), the maximum droplet velocity
915 happens when the diameter of droplet is equal to the attenuation length²⁰⁸. For smaller
916 diameters of droplet, the whole SAW energy is not absorbed by the droplet. However, droplets
917 with larger diameters move slower because the same amount of applied SAW energy was used
918 to move a higher mass.

919 If the droplet viscosity becomes larger, the pumping velocity significantly decreases for small
920 droplets (from 2 to 20 μl)²⁰⁹. The necessary power to deform and move a sessile droplet could
921 be reduced between 50 to 75% through vibrating the droplet. This approach is important for
922 cases for which temperature needs to be kept a constant. Another method to decrease the
923 acoustic power required to transport a droplet is using SAW inertia-capillary modes of
924 oscillation. For example a 19.5 MHz straight IDT can be used with Rayleigh-Lamb inertia-
925 capillary modes to move a droplet at a speed of 5 mm/s with the required power reduced by a
926 factor of 3²¹⁰.

927 Surface properties can affect the droplet pumping velocity with SAWs. A superhydrophobic
928 surface would minimize the contact area between liquid and solid and reduce the pinning force,
929 making the surface slippery. However, this minimized interaction area limits the amount of the
930 energy which can be transferred by the SAW to the liquid medium. Droplets with lower
931 volumes at higher applied RF voltages are transported with higher velocity on hydrophobically
932 treated surfaces ²¹¹. Pumping of droplets with volumes up to 10 μl can be achieved using a
933 straight IDT on a thin-film piezoelectric material treated with a hydrophobic self-assembled
934 monolayer of octadecyl trichlorosilane (OTS) ²¹¹. A slippery layer of lubricating oil-filled
935 hydrophobic surface can also be used, and the threshold power to pump the droplet on a ZnO/Si
936 SAW device can be significantly reduced (up to 85%) ²¹². The surface behavior of droplet
937 manipulation in microfluidics is discussed in detail by Wu *et al* ²¹³.

938 Droplet acoustofluidic devices typically need a flat surface to operate correctly. However,
939 changing the surface treatment and using thin-film SAW devices, such as ZnO/Si, ZnO/glass,
940 AlN/Si ²¹⁴ or ZnO/Al, can achieve droplet transportation across a wide range of substrates and
941 their geometries, including inclined, curved, vertical, inverted, and lateral positioned surfaces⁴⁰
942 (Figure 8(b)).

943 Transporting droplets across different piezoelectric substrates could be helpful if each separate
944 substrate has a different function, such as mixing and separating, rather than a substrate with
945 all the operating units. For example, it is possible to use three 128° Y-X LiNbO₃ substrates
946 each with their own 27.5 MHz IDT and reflector, where one is an interface chip and two are
947 working chips 1 and 2 ²¹⁶. The interface chip can be adjusted to be the same height as working
948 chip 2 with a gap as small as possible so that the SAW can transport the droplet across.
949 Similarly, the droplet can be transported to working chip 1 by adjusting the height. It should
950 be noted that although many of these methods for droplet translation do not use a FIDT, if a
951 droplet is placed on the focal distance of an 13 MHz FIDT, it can move approximately five
952 times faster than a straight IDT when compared to a straight IDT of the same frequency and
953 dimension ²¹⁷.

954 Small-scale programmable microfluidic processing can be accomplished by using SAW
955 streaming to actuate and transport droplets along predetermined trajectories. Chemical
956 modifications of the chip surface can be used to design the paths to create virtual wells and
957 tubes (hydrophilic and hydrophobic regions) which confine small droplets. Depending on the
958 actual layout of the chip/IDTs, the droplets can be split into smaller ones, merged, mixed, and

959 processed ²¹⁸. Instead of predetermined trajectories, acoustic streaming induced hydrodynamic
960 traps can be used for contactless droplet transport and manipulation of droplets within volumes
961 between 1 nL to 100 μ L along any planar axis. For example, using four straight IDTs to create
962 an 8 by 8 array (Figure 8(c)), the streaming effect pushes fluid out along one direction, and
963 pumps the fluid (with fluorinated oil as carrier layer) along the vertical directions ¹⁷⁶. The
964 acoustic streamlines converge at two horizontal stagnation points above the two symmetric
965 sides of the IDT, hence the water droplets floating on the oil can be trapped ²¹⁹. The re-
966 programmable digital multi-path platform can achieve various droplet manipulation (transport,
967 merge, mix and split) and can be scaled to perform massive interaction matrices within a single
968 device.

969 IDT arrays inside a layer of oil can generate acoustic streaming vortices for rewritable digital
970 acoustofluidics, contact-free routing and active/passive gating ⁴⁵. Droplets over the transducer
971 are guided to the center hydrodynamic equilibrium position between barrel-like acoustic
972 streaming vortices. The vortices are extended to the adjacent transducers when multiple
973 transducers are sequentially activated using multi-toned electrical signals. Hence a long virtual
974 channel for unidirectional transportation and gating can be produced ⁴⁵. These programmable
975 microfluidic processing techniques offer basic functional units that mimic electronic
976 functionality for biomedical and biochemical applications such as on-chip bioassays, high
977 throughput compound screening, biochemical synthesis, and droplet processing strategies that
978 follow digital logic rules ⁴⁵.

979 **Jetting**

980 Jetting can be generated by concentrating the wave energy into a small, focused area and
981 maximize the mechanical displacements into sessile droplet. A nozzleless method to jet liquid
982 can be beneficial in 2D and 3D bioprinting, needle-free fluid injection or single-molecule
983 detection. It offers the advantages of being low cost, simple manufacturing, and the ability for
984 miniaturization. Jetting can be achieved with a standard SAW devices such as on a substrate
985 of 128° Y-X LiNbO₃ (Figure 8(d)) surface-treated with hydrophobic layer, so long as the SAW
986 streaming force is large and strong enough to expel a droplet from the substrate ¹⁰⁴. Jetting can
987 even be generated along inclined or bent surfaces using thin-film materials such as AlN/Si
988 Rayleigh SAW device ²¹⁴.

989 With a single IDT, the droplet is generally ejected along the Rayleigh angle (e.g., 23° on a 128°
990 Y-X LiNbO₃ substrate) in the SAW propagation direction. Vertical jetting phenomena can be

991 generated from an SH-SAW device with a single straight IDT made on a 36° Y-X LiTaO₃
992 substrate, which is drastically different from those from the conventional Rayleigh SAWs
993 ^{220,221}. The SH-SAW propagates with a relatively shallow energy penetration into the droplet.
994 The energy and pressure are distributed randomly between the droplet and the surface in the
995 whole contact area. The wave energy/pressure is mainly concentrated at the center of the
996 droplet and vertically dissipated, causing vertical jetting ²²¹.

997 Focused IDTs can generate increased concentration for droplet jetting and ejecting applications
998 ²⁹, which can be significantly affected by the substrate's wettability ¹²¹. A pair of FIDTs can
999 extend a pendulous droplet to form a liquid bridge with a second substrate underneath it. This
1000 straightforward method makes it possible to build capillary bridges for the low viscosity
1001 liquids, such as water, to investigate their capillary-thinning behavior ²²².

1002 Single droplets can be ejected into the air by also using a pair FIDTs (Figure 8(e)), where the
1003 droplet size can be adjusted by the pulse width duration, and on-demand repetitive droplet
1004 ejection can be managed by continuously resupplying a parent drop reservoir ²²³. Such device
1005 can also be used to enable the encapsulation of single CTCs ^{224–226} and rare cryopreserved cells
1006 ²²⁷, as well as an acoustic droplet-based printing of tumor organoids ³⁹ and tumor
1007 microenvironment ²²⁸. Acoustic single-cell printing provides the ability to study cell
1008 heterogeneity toward the development of personalized cancer medicine and predicting the
1009 responses of tumors to therapy ³⁹. Such a nozzle-free, contact-free, and low cell-damage
1010 method will surely advance the bioprinting technology. However, it should be noted that there
1011 is a significant temperature increase of an FIDT device in water, and thus issues about high-
1012 temperature sensitivity of biological tissues and cells should be considered ²²⁹. Single straight
1013 IDTs can also be patterned on the underside of a chip and generate surface reflected bulk waves
1014 (SRBWs) on a hybrid resonant acoustic (HYDRA) platform (Figure 8(f)) ²³⁰. This specially
1015 designed droplet ejecting method can protect the device as the liquid does not need to contact
1016 directly with the IDT or piezoelectric substrate ²³¹, and thus enables a modular and
1017 reconfigurable platform with individual chips in a 96 well plate.

1018 Focused SAWs induced jetting can be easily generated using the annular pattern IDTs (Figure
1019 8(g)). For example, a sample reservoir on top of a piezoelectric substrate with an AIDT can
1020 form picolitre (24 pL) droplets within 10 ms and encapsulate a single cells ²³². Multiple AIDTs
1021 can be combined to create a 4×4 two-dimensional ejector array which can generate drop-on-
1022 demand and continuous mode of operation 28 μm diameter droplets ²³³. This open pool and

1023 nozzleless reservoir means that droplet directionality is easily controllable with reliable
1024 ejection outcomes. Nevertheless, as mentioned previously, due to the significant anisotropic
1025 effect of such piezoelectric materials, unique designs are needed to correct the differences in
1026 acoustic velocities for an efficient or focused effect, leading to more complex modelling and
1027 mask designs ²³⁴.

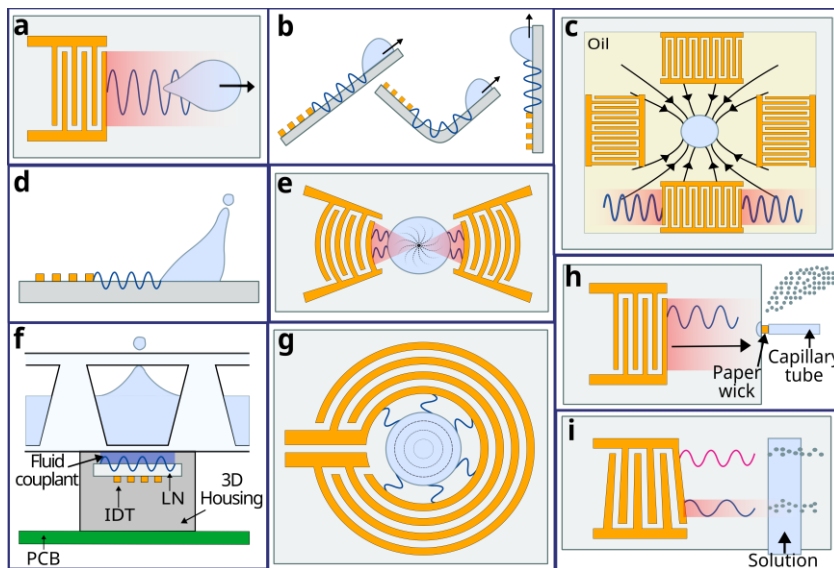
1028 Thin-film SAW devices such as using ZnO or AlN ²³⁵ not only have isotropic wave velocities
1029 but offer higher power handling capability. In-plane isotropic ZnO/Si circular SAW with an
1030 AIDT can produce vertical droplet jetting. Compared with 128° Y-X LiNbO₃ AIDT, ZnO
1031 annular SAW shows controllable, concentrated, thin liquid generated, whereas LiNbO₃ does
1032 not result in a highly concentrated thin liquid column ³⁰. However, the electro-mechanical
1033 coupling coefficient of ZnO SAW device is much lower than that of 128° Y-X LiNbO₃, thus
1034 the jetting could be relatively weak ²³⁶. The jetting efficiency can be improved by introducing
1035 an ultra-smooth nanocrystalline diamond (UNCD) interlayer to a ZnO/Si device ²³⁷, which can
1036 help to increase the amount of the SAW energy transferred from the solid surface to the liquid
1037 medium.

1038 **Nebulization**

1039 Atomization and nebulization are methods to generate fine aerosol droplets important for
1040 numerous applications where small, similar-sized droplets are needed, such as spray cooling,
1041 inhalation therapy for drug delivery, mass spectrometry and bioprinting. Compared to other
1042 methods, they can generate monodispersed microdroplets with minimal shear and cavitation,
1043 preventing biomolecule damage due to their high frequencies and low powers. Nebulization
1044 can be carried out directly from the substrate using a single IDT (Figure 8(h)) ^{238–241}. For
1045 example, such a device has been demonstrated to nebulize epidermal growth factor receptor
1046 monoclonal antibodies into a fine aerosol mist for pulmonary delivery, which is beneficial for
1047 lung cancer treatment ³². Moreover, a single IDT can use a SRBWs to achieve higher output,
1048 greater efficiency and efficacy. This type of wave propagates along and through the substrate,
1049 therefore it can draw the solution from a vial through the needle in contact with the substrate,
1050 and then nebulize the liquid ²⁴². Therefore *in vitro* pulmonary delivery of antibiotic alternatives
1051 can be successfully achieved against *Staphylococcus aureus* ³⁸ as well as *in vivo* human lung
1052 deposition ²⁴².

1053 The droplet size of mist generated by atomization can be controlled by adjusting the physical
1054 properties of the liquid and the input power to the device ³². For example, thin-film liquid

1055 geometries can lead to smaller droplets and higher atomization rates, mainly due to the higher
 1056 frequency used and much concentrated effects on the surfaces ³¹. A thin graphene film
 1057 deposited on 128° Y-X LiNbO₃ combined with an focused SPUDT can have up to 55%
 1058 enhancement in the rate of fluid atomization ²⁴³. Based on a comparison of SAW atomization
 1059 for spray cooling with a focused SPUDT versus a SF-IDT, the focused SPUDT achieves higher
 1060 efficiency. However, the SF-IDT allows placement of atomization at a specific location within
 1061 the SAW device (Figure 8(i)) ²⁴⁴. By using a pair of FIDTs on a ZnO/Si device with a relatively
 1062 large arc angle (90°) of the IDT, it is possible to achieve an increased nebulization rate, reduced
 1063 critical powers required to initialize nebulization, and concentration of the nebulized plume
 1064 into a narrower size of spray ³⁴.



1065
 1066 Figure 8. Pumping, jetting and nebulization for digital acoustofluidics IDT device examples.
 1067 (a) Singular straight IDT on a horizontal surface and (b) inclined, curved, vertical, inverted and
 1068 lateral surface for TSAW droplet transport ⁴⁰. (c) One unit consisting of a four straight IDT
 1069 array (one pixel) for digital microfluidics ¹⁷⁶. (d) Singular straight IDT and (e) pair of FIDT
 1070 for TSAW droplet jetting. (f) Singular Straight IDT on the underside of a chip for SRBW
 1071 HYDRA Platform droplet ejecting ²³⁰. (g) An annular IDT for TSAW droplet jetting ²³². (h)
 1072 Singular straight IDT and (i) SF-IDT for TSAW nebulization.

1073 **5.1.3. Mixing, concentration, and rotation of liquid in chamber/channel for continuous**
 1074 **acoustofluidics**

1075 **Mixing**

1076 When mixing in a microchannel or a chamber, it is convenient to use a straight IDT to overcome
1077 diffusion limitations in the microscale liquid. It can support nanoparticle production²⁴⁵ or
1078 increase reaction yield in the microchannel for biosensing applications²⁴⁶. When this
1079 configuration is combined with a surface plasmon resonance microfluidic sensor, SAW mixing
1080 can aid in alternative applications such as surface chemical and biochemical functionalization
1081 by improving functionalization efficiency up to 5 times with respect to that without using
1082 SAWs²⁴⁷. The key parameters to control acoustic mixing in microchannels are the SAW
1083 power, flow rate and fluid viscosity^{245,248}. A SAW device with a thick PDMS channel can lead
1084 to acoustic wave attenuation and hence much SAW power could be lost. A single IDT can also
1085 be used directly underneath a PDMS microchannel to generate strong acoustic streaming for
1086 fluid mixing, and using this method, a total flow rate of 50 $\mu\text{l}/\text{min}$ at a low power consumption
1087 (e.g., 12 V_{pp}) can be achieved²⁴⁹. To control mixing speed and flow patterns, an SF-IDT was
1088 used to optimize SAW amplitude and frequency due to the narrow SAW beam and variable
1089 launching point^{144,250,251}.

1090 When comparing FIDTs with the straight IDTs, the focused acoustic radiation creates a high
1091 acoustic wave intensity that enhances mixing performance in a specific microchannel region
1092 (Figure 9(a))²⁵². For example, a 100.4 MHz single FIDT device can apply considerable
1093 pressure to a small region that can be focused on a water droplet on an ultrasonic coupler
1094 between a SAW device and a cell culture dish, which can facilitate the local removal of cells
1095 from a culture surface⁴². A singular FIDT can be used with a dome-shaped chamber, and can
1096 achieve mixing ratio higher than 0.9 at a total flow rate of 300 $\mu\text{l}/\text{min}$ at 20 V⁴¹. The chamber
1097 acts as a more stabilized droplet that maximizes the effect of SAW transmitted at a refraction
1098 angle of roughly 22° with a contact angle of 68° .

1099 To enhance mixing, one could consider the addition of bubbles in the channel^{253–257}. If trapped
1100 air bubbles are excited by acoustic waves at their resonance frequency, acoustic streaming is
1101 induced and improves the fluid mixing by disrupting the laminar flow. For example, this
1102 method can mix highly viscous fluids within 50 milliseconds²⁵⁵. Nevertheless, there are
1103 concerns of bubble instability, heat generation, and inconvenient bubble trapping processes;
1104 hence other methods to enhance streaming based mixing should be considered. The geometry
1105 of the channel plays a crucial role in acoustic streaming vortices and mixing. For example,
1106 using a sharp edge^{258–267} generates a large Reynolds body force when compared to non-sharp
1107 edges²⁵⁸, which has proven effective in mixing²⁶⁵, cell lysis²⁶⁸, pumping²⁶⁹ and rotation^{270,271}.
1108 Such acoustic streaming enhancement is not limited to sharp edges, other microstructures^{272,273}

1109 can be used such as microcylinders^{274–276}, micro square pillars²⁷⁷, and micro
1110 parallelepipeds^{273,278}.

1111 The mixing efficiency could also be improved using three-dimensional dual SAWs generated
1112 from two focused SPUDT devices. Each of them was patterned on a piezoelectric substrate,
1113 thus achieving 100% mixing efficiency at a flow rate of 50 $\mu\text{l}/\text{min}$ for 14 V or 95.6% efficiency
1114 at a flow rate of 120 $\mu\text{l}/\text{min}$ for 18 V²⁷⁹. Hence, two focused acoustic waves were introduced
1115 from the top and bottom substrates in diagonally opposite directions, and induced micro
1116 swirling with the same rotational direction, which enhanced mixing performance²⁷⁹. It should
1117 be noted that although the techniques mentioned above contain the typical solid metal
1118 electrodes, other materials such as a conductive liquid-based FIDT can be used, which achieved
1119 a mixing efficiency higher than 90% at a flow rate lower than 120 $\mu\text{L}/\text{min}$ and 21 V²⁸⁰.

1120 SAW can induce vibrational mixing by using SAW devices with high frequencies and lower
1121 continuous powers, compared to lower frequencies or with short but very intense pulses. Low
1122 frequencies have longer attenuation path lengths that can produce strong reflections, hence
1123 creating dominant SSAWs that suppresses the acoustic streaming. Unlike using short but very
1124 intense pulses, using low power by continuous signals is beneficial for applications which need
1125 mechanical stimulations, yet ensure that both cavitation and heating are negligible. For
1126 example, low power and single 100 MHz SAW device was used for vibration enhanced cell
1127 growth²⁸¹. A 20 MHz device was used for accelerated neural differentiation of human
1128 embryonic stem cells¹⁷⁸. Another 30 MHz FIDT device at 20% duty cycle was used to trigger
1129 intracellular calcium responses in HEK293T²⁸². Due to the absence of cavitation generated at
1130 such a low power and high frequency, the 30 MHz focused SPUDT can effectively enhance
1131 the uptake of difficult-to-transfect nonadherent cell lines such as suspension T cells in just 10
1132 min of exposure while maintaining high cell viabilities (>91%). This is much better if compared
1133 to other methods such as conventional nucleofection of 76%, which is one of the most widely
1134 used intracellular delivery methods²⁸³.

1135 **Concentration and separation**

1136 Concentration of particles and cells within a channel and then separation have been typically
1137 realized using acoustic radiation forces¹⁰² with SSAWs, where the objects migrate toward
1138 minimum PNs or ANs. This methods allows for concentrating and separating extracellular
1139 vesicles^{284 285} and CTCs^{286 287}. Nevertheless, there was also reports that a single IDT with a
1140 designed frequency of 49.5 MHz can be used to generate TSAW for separation of 10 and 25

1141 um particles in a microchannel ¹⁷⁷. A combination of acoustic radiation force and acoustic
1142 streaming force can also be realized in multi-stage acoustic devices (Figure 9(b)). For example,
1143 Wang *et al.* uses a pair of straight IDTs to generate SSAW to focus CTCs and RBCs at the
1144 pressure nodes without the requirement of the sheath flow, and the pulsed focused TSAW uses
1145 acoustic streaming to push the CTCs away from RBC for CTC isolation ²⁸⁸. If a pair of
1146 opposing straight IDTs are of different frequencies, two counterpropagating decaying TSAWs
1147 would be produced which can be used for particle sorting. This method allows a much longer-
1148 range force field, in which migration takes place across multiple wavelengths, and causes
1149 particles to be gathered together in a single trapping site ²⁸⁹.

1150 Large amplitude and high frequency FSAWs cause strong acoustic streaming to generate fluid
1151 streamlines and vortices. This allows for functions such as size selective aggregation down to
1152 300 nm in a closed channel ²⁹⁰, selective capture of 2 μm particles from mixing suspension of
1153 1 μm particles in a continuous flow ²⁹¹, and constant differential focusing of nanometer
1154 particles in a continuous channel (see Figure 9(c)) ¹¹. This configuration can be combined with
1155 hybrid microfluidic cell sorting techniques such as using a reverse wavy ²⁹² or spiral ²⁸⁷
1156 microchannel for passive inertial cell enrichment and as well as active TSAW single cell
1157 sorting. It could be a promising solution for practical biomedical applications as it provides
1158 high throughput and high accuracy isolation of rare cell populations.

1159 **Rotation**

1160 The same approach, by which IDTs can generate an acoustic streaming vortex in a channel,
1161 enables contactless rotation of small veritable models ^{37,270}. Such rotational tweezing enables
1162 high-speed, 3D multispectral imaging and digital reconstruction, which yields accurate 3D
1163 models for quantitative evaluation of morphological characteristics and advanced
1164 combinations metrics useful for small organism phenotyping, screening, and microsurgery. For
1165 example, rotation of *Caenorhabditis elegans* can be achieved by simply using a pair of straight
1166 IDTs with a frequency 19.32 MHz and activating one at a time to create a single vortex and
1167 hence rotate along the corresponding acoustic streaming direction ³⁷. However, the vortex size
1168 is limited and insufficient to rotate large organisms in the millimeter scale. Rotating larger
1169 organisms, such as zebrafish larvae are commonly used in rapid drug screening and disease
1170 evaluation, hence it is vital to develop functional platforms for clear visualization and accurate
1171 analysis for high throughput phenotypic evaluations. Quantification and 3D reconstruction can
1172 be achieved by rotating the zebrafish larvae using a straight IDT and a patterned fluidic channel

1173 aligned on and parallel to the lateral side of the IDT with half of its width on the IDT³⁶ (Figure
1174 9(d)). The fluid above the IDT forms a strong, stable, and consistent single unidirectional
1175 vortex pattern³⁶.

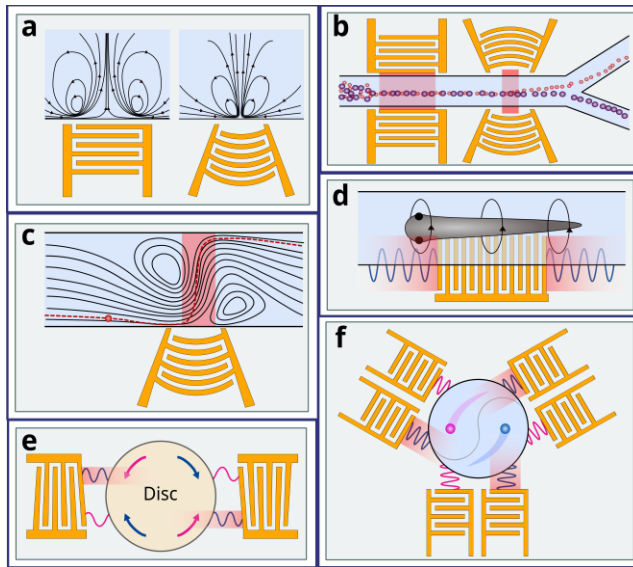
1176 The designed rotation mechanism can be used to manipulate and drive objects, such as a
1177 centrifugal microfluidic platform. For example, a miniaturized lab-on-a-disc (miniLOAD)
1178 SAW device with two offset FIDTs was reported in Ref.²⁹³. The acoustic streaming drove the
1179 rotation of thin millimeter discs atop of a fluid coupling layer, on which microchannels was
1180 fabricated so that operations can be achieved. By adding a second pair of opposing offset
1181 FIDTs, the rotational velocity and direction of the disc can be controlled by altering the input
1182 frequency to the transducer²⁹⁴. Moreover, a pair of opposite SF-IDTs can be used for the
1183 miniLOAD device to alter the frequency when a disc of a different size needs to be used (Figure
1184 9(e))²⁹⁴.

1185 Compared to these large-scale structures, precise rotation and manipulation of microparticles
1186 in a channel need precisely controlled. For example, using six IDTs (divided into two sets) and
1187 symmetrically distributed around an annular shaped changer at an angle of 120° can lead to tri-
1188 directional symmetrical acoustic tweezer²⁹⁵ as shown in Figure 9(f). Here the TSAWs are
1189 generated to precisely control microparticle movements which allows programmable motion
1190 control by switching the excitation combinations of IDTs, producing linear, clockwise, and
1191 anticlockwise trajectories. An array of IDTs, designed in relation to the anisotropic properties
1192 of the substrate, can also produce similar swirling acoustic vortices for fluid actuation and
1193 particle manipulation¹⁵⁸. Similarly, an array of piezoelectric transducer plates can produce
1194 stable, symmetric pairs of vortices to create hydrodynamic traps for object manipulation²⁹⁶. In
1195 fact, acoustic tweezers can be achieved without a complex transducer array yet manipulate a
1196 wide range of particle sizes. With a single transducer, the acoustic radiation force in two
1197 dimensions is combined with an acoustic streaming vortex for levitation in the third
1198 dimension²⁹⁷.

1199 **Droplet manipulation**

1200 Fluid in a droplet form in another liquid within a microchannel can be controlled through
1201 acoustic streaming. For example, an SF-IDT in an H-shaped junction for the regulated flow
1202 switching between two fluid streams⁴³. Likewise, liquid droplets in a microchannel can be
1203 precisely controlled for applications such as isolated microenvironments without cross-
1204 contamination²⁹⁸. It was reported that droplets can be selectively merged using an SF-IDT to

1205 trigger the biochemical reactions ²⁹⁹ ²⁹⁸, encapsulate samples ³⁰⁰, or using an FIDT to
 1206 selectively dispense based on their volumes ³⁰¹. Nanoslit channels have also been created and
 1207 combined with the TSAW streaming to perform notoriously difficult nanoscale manipulation
 1208 due to the dominance of surface and viscous forces ^{302,303}. Using a straight IDT, controllable
 1209 manipulation of 200 fl ³⁰² and 10 fl ³⁰³ droplets in a nanofluidic channels have also been
 1210 achieved. The ability to manipulate droplets in these nanostructures makes it useful for
 1211 increasing the sensitivity of analytical tools for applications such as medical diagnostics and
 1212 personalized treatments.



1213
 1214 Figure 9. Mixing, concentration, and rotation of liquid in chamber/channel IDT device
 1215 examples. **(a)** The acoustic streaming generated by straight vs. focused IDT in a closed channel.
 1216 **(b)** Multistage device for tumor cell isolation. The device consists of pair of straight IDTs for
 1217 SSAW concentration and a pair of FIDT for TSAW isolation. **(c)** The acoustic streaming of a
 1218 focused IDT in a continuous flow, acting to direct particle laterally **(d)** Rotational manipulation
 1219 of zebrafish larvae ³⁶. The device consists of a straight IDT and a patterned fluidic channel
 1220 aligned on and parallel to the lateral side of the IDT with half of its width on the IDT. **(e)** A
 1221 pair of SF-IDT for bidirectional rotating of a thin disc over of fluid coupling layer. **(f)** Tri-
 1222 directional symmetrical acoustic tweezers for programmable trajectory manipulation ²⁹⁵. The
 1223 device comprises six IDTs (divided into two sets) and is symmetrically distributed around an
 1224 annular-shaped changer at an angle of 120°.

1225

1226 **5.2. SSAWs based streaming and acoustofluidics**

1227 **SSAWs generate...** insert into SSAW text here like in TSAW section 5.1, and include**
 1228 **information on Figure****

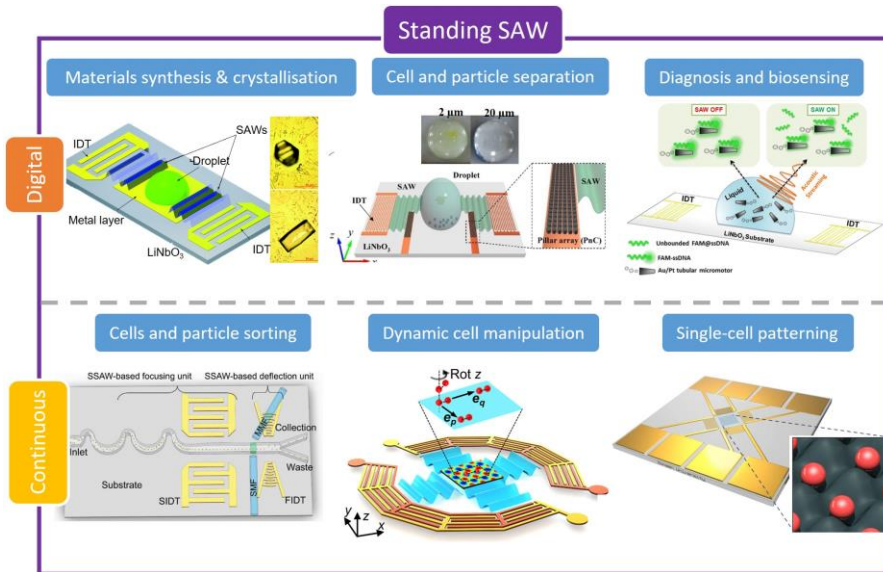


Figure X. Examples of real-life medical applications of SSAW streaming, for both digital and continuous acoustofluidics. **SSAW digital: (left)** A SSAW device with drop of glycine solution for crystallization. Reproduced with permission.³⁰⁴ Copyright 2018, Royal Society of Chemistry. **(middle)** A phononic-crystal device generating scattered SSAW for cell and particle separation. Reproduced with permission.³⁰⁵ Copyright 2018, Elsevier. **(right)** SSAW device for the removal of molecules that are unbound to micromotors, realized for lowering the detection limit of the cancer-related biomarker miRNA-21. Reproduced with permission.³⁰⁶ Copyright 2021, American Chemical Society. **SSAW continuous: (left)** A SSAW based fluorescence-activated cell sorter with a 3D cell-focusing unit, an in-plane fluorescent detection unit, and a cell-deflection unit on a single chip. Reproduced with permission.³⁰⁷ Copyright 2018, Wiley. **(middle)** Wave-number acoustic tweezers that enable dynamic reshaping of the SSAW wavefields, achieving dynamic and reconfigurable particle manipulation. Reproduced with permission.¹⁵² Copyright 2019, Science Advances. **(right)** A two-dimensional SSAW device, with four IDTs, for one cell per acoustic well patterning. Reproduced with permission.³⁰⁸ Copyright 2015, Nature Communications.

1229

1230 **5.2.1. SSAW induced droplet streaming in digital acoustofluidics**

1231 When SSAWs generated using a pair of IDTs actuate a sessile droplet, it results in symmetric
 1232 acoustic wave propagations and creates a strong acoustic streaming force inside droplet, even
 1233 though the droplet might not be easily moved. Therefore, SSAW induced streaming is
 1234 beneficial for stable mixing and jetting of sessile droplets. For example, SSAW mixing can

1235 increase the kinetic effect to influence the recrystallization process of metal organic
1236 frameworks (the best-known being HKUST-1 crystals)³⁰⁹ and glycine³⁰⁴ with different
1237 morphologies and sizes in a droplet, as well as isolate sodium chloride crystals in a drying
1238 droplet³¹⁰. This mixing effect has great potentials in drug delivery and/or release for
1239 pharmaceutical industry. The SSAW induced mixing allows for direct, safe and high efficiency
1240 mixing, facilitating the dynamic cell culture³¹¹, labelling of nanoparticles³¹², or lowering the
1241 detection limit for biomarkers³⁰⁶. SSAW generated using a pair of small-aperture-straight-
1242 electrodes (SASE) in a vertical capillary tube has also been utilized for standardized and
1243 controllable droplet jetting³¹³. The SASE device has a higher energy density output
1244 performance and higher driving capability than large aperture SAW devices which ensures
1245 energy concentration and more standardized wave paths³¹³.

1246 Although droplet transport in liquid within channel is not as easily achieved with SSAWs, it
1247 can be achieved by SSAW induced streaming using a pair of straight IDTs in conjunction with
1248 anisotropic ratchet conveyors, which use hydrophilic patterns of background to control the
1249 directional movement of the droplet transport (Figure 10(a))³¹⁴. Additionally, this
1250 configuration can confine the droplet position to allow for nebulization controlled by the SAW
1251 frequency³¹⁴. Scattered SSAWs can be produced using pairs of opposing IDTs and nickel pillar
1252 type crystals to control the SAW field (Figure 10(b)). In a sessile droplet, the SSAW can
1253 simultaneously induce strong acoustic streaming localized on half a region and directional
1254 propagating longitudinal acoustic waves³⁰⁵. This mechanism has been used for concentration
1255 and separation of 2 and 20 μm PS particles in a microliter droplet³⁰⁵.

1256 **5.2.2. SSAW induced streaming in microchannel for acoustic tweezers in continuous** 1257 **acoustofluidics**

1258 The simplest way to generate SSAWs is by using a pair of IDTs. Two counter propagating
1259 waves interact, forming a time-averaged nodal and anti-nodal periodic patterning positions
1260 across the entire channel¹⁷⁴. Therefore, SSAWs can easily create one dimensional nodal lines
1261 inside channels or chambers³¹⁵ for applications such as separation of encapsulated cells³¹⁶,
1262 extracellular vesicles^{284,285} or CTCs^{286,287}. For example, tunable cell sorting of human white
1263 blood cells (WBC) (15 μm) and fluorescent PS beads (10 μm) was achieved using a pair of
1264 chirped IDT and a multi-channel sorting device³¹⁷. This was further developed by acoustically
1265 sorting different sizes such as platelets, RBCs and WBC³¹⁸. Tilted angle SSAWs³¹⁹ (Figure
1266 10(c)) can be used to increase separation differences between similar sized particles, hence it

1267 can be used for cancer cell manipulation ³¹⁵ and separating exosomes from whole blood ³²⁰.
1268 Phase modulation-based SSAW techniques are another advanced method to increase separation
1269 throughput as it uses multiple pressure nodes without the need to increase channel width ³²¹⁻
1270 ³²³.

1271 Multiple IDTs can be easily integrated for such applications, for example, two pairs of IDTs
1272 can be used to achieve multi-stage SAW concentration and separation (Figure 10(d)) ³²⁴⁻³²⁶.
1273 The first stage is consisted of a pair of IDTs for particle/cell sorting by SSAWs. The second
1274 stage is consisted of an IDT, such as a straight IDT, SF-IDT or F-IDT to form TSAWs for
1275 particle/cell deflection ^{288,307,327}. Conventional SSAWs result in particle and cell patterning
1276 across the entire width of a microfluidic channel, preventing selective trapping, whereas
1277 applying nanosecond-scale pulses can generate localized time-averaged patterning regions for
1278 selective trapping ³²⁸.

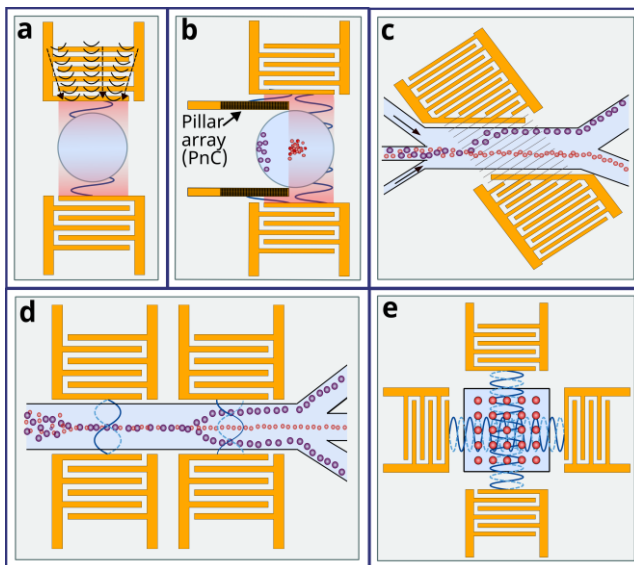
1279 Additional IDTs, for example, two orthogonal pairs of IDTs (Figure 10(e)), ^{27,329} can be used
1280 to form a 2D pattern of nodes and antinodes for particle manipulation ^{308,330,331}. The 3D spatial
1281 distribution of the cells, and preserve the viability and functionality of the patterned cells
1282 suitable for tissue engineering applications. In such an orthogonal pair IDT setup, intelligent
1283 modulation of harmonic waves can be used to generate time-effective Fourier-synthesized
1284 acoustic potential wells, allowing particles/cells in suspended fluids and acoustic lattices to be
1285 spatially controlled and reconfigured ³³². Additionally, SSAW generated by SF-IDT can
1286 spatially localize cells encapsulated within a gelatin methacryloyl hydrogel matrix ³³³. SSAWs
1287 allow particles and cells to be patterned into 3D spatial lines or crystal-lattice-like matrix
1288 patterns in chambers of millimeter height ³³⁴ (for example, such a chamber is large enough for
1289 entire organism manipulation of *Caenorhabditis elegans*) ¹⁴¹, or formation of multicellular
1290 spheroids ^{335,336}. These SSAW 3D patterns have also been effectively realized using alternative
1291 piezoelectric thin film SAW platform such as ZnO or AlN films, instead of LiNbO₃ ³³⁷.

1292 Acoustic tweezers with generated torque forces using SSAWs could be obtained using a
1293 temporal phase lag between the two standing waves, leading to a complex pressure field. The
1294 superimposed acoustic streaming induced fluid motion creates stable 3D trapping nodes within
1295 a chamber. This method allows for single cell manipulation ³³⁸ and controlled rotation and
1296 translation of spherical particles or living cells in a 3D format ³³⁹. A wave number-spiral design
1297 for acoustic tweezers can enable frequency-based steering of SSAW for simultaneous and
1298 independent control. This method only needs two multitone excitation signals which enables

1299 the resultant SAW wavefields to be dynamically reshaped without using complex and costly
1300 electronics ¹⁵².

1301 SSAWs can also influence the fluid streaming patterns in a chamber. For example, the mixing
1302 performance with two opposing parallel straight IDTs (96.7%) is much higher than with one
1303 straight IDT (69.8%) as the same applied voltages ($85 V_{p-p}$) and flow rates ($10 \mu\text{l}/\text{min}$) ³⁴⁰. The
1304 mixing behavior induced by SSAW acoustic streaming can be beneficial in preventing particle
1305 deposition in a microchannel ³⁴¹, or generating microextraction functions for biochemical
1306 analysis applications ^{342,343}.

1307 In brief, acoustic tweezers with functions for patterning and particle manipulation based on
1308 SSAWs have been a research hot topic in the acoustofluidic field, and have been
1309 comprehensively reviewed in many papers ^{22,24,49,344–346}. Therefore, this paper will not discuss
1310 further. For these developments and readers should refer to the above or other review papers
1311 for more information.



1312
1313 Figure 10. SSAW induced droplet streaming in digital acoustofluidics and microchannel for
1314 acoustic tweezers in continuous acoustofluidics IDT device examples. (a) A pair of straight
1315 IDTs and anisotropic ratchet conveyors for controllable droplet transport ³¹⁴. (b) A pair of
1316 straight IDTs and nickel pillar-type crystal arrays (PnC) which obstruct the lower half of SSAW
1317 to produce scattered SSAW for particle concentration and separation ³⁰⁵. (c) Tilted angle
1318 SSAW ³¹⁵ and (d) Multi-stage SSAW using two pairs of straight IDTs for particle separation.
1319 (e) Two orthogonal pairs of IDTs for SSAW particle manipulation (acoustic tweezers).

1320

1321 **6. Summary and future prospects**

1322 This review aims to elucidate the underlying mechanisms, design methodology, techniques,
1323 and applications of acoustic streaming for various acoustofluidic applications. SAW
1324 technology is in high demand due to its function as both sensors and actuators in various
1325 disciplines. It offers efficient, non-invasive, and biocompatible devices that are valuable for
1326 biological research and clinical applications such as diagnosis and therapeutics, health
1327 monitoring, and biosampling/treatments. IDTs have their own developed design criteria
1328 whereby the IDT materials and geometries, as well as the piezoelectric material, can be
1329 changed, allowing for various functions of manipulation control for specific applications. Not
1330 only can the device be designed for a specific application, but also it is possible to design
1331 programmable features useful for microfluidic processing in applications such as on-chip
1332 bioassays, high throughput compound screening and biochemical synthesis. They can also
1333 achieve single droplet processing strategies that follow a digital logic rule. The highly sensitive
1334 and selective yet simple and low-cost nature of IDTs makes them suitable for lab-on-chip and
1335 point-of-care devices.

1336 Acoustic streaming generates regions of recirculation or pressure gradients that lead to rapid
1337 and localized motion, allowing it to manipulate particles, such as patterning, concentration, and
1338 separation. Such the manipulation is useful for applications such as CTC separation, single cell
1339 analysis and even submicron manipulation of exosomes. Acoustic streaming can also generate
1340 acoustic pressure or force to perform operations such as deformation, transportation, and
1341 manipulation of bulk fluid in a droplet format, namely jetting, nebulization or atomization,
1342 microscale streaming, and object rotation. This establishes advanced technologies, such as 3D
1343 bioprinting or rotational tweezing for 3D multispectral imaging and digital reconstruction of
1344 models.

1345 In brief, this review paper provides qualitative and quantitative descriptions of the acoustic
1346 streaming mechanism and recent developments. It presents a snapshot of its remarkable
1347 contributions to biomedical research and clinical science. Despite this review showing that
1348 much has been accomplished with acoustic streaming-based acoustofluidics, it is important to
1349 address that there is a huge amount of work to be done. Some major topics for future
1350 development are highlighted as follows.

1351 **Mechanisms, theory, and modelling**^{2,27,50} –

- 1352 • Analysis techniques need to be further improved. This is because the basic equations
1353 used in the analysis have borrowed directly from the classic derivations, which are
1354 convenient but might not be accurate for micro or nanoscale acoustofluidics.
- 1355 • There are specific topics which need to study, for example, nonlinearity, viscous,
1356 boundary, inertia, and temperature effects and strongly chaotic phenomena of the waves
1357 propagating inside the fluids and its effects on the fluid and particles movements and
1358 flow.
- 1359 • Studies need to be focused on improving computational modelling for acoustic
1360 streaming problems in three dimensions for mixed fluids, geometries, and frequency
1361 regimes, as well as the nonlinear interactions between the liquid and particles ⁵⁰.
- 1362 • The large discrepancy in time and space domains between the driving SAW and the
1363 resulting liquid streaming which remains poorly understood. Hence challenges with
1364 numerical computational simulations as a very small time step and a very fine mesh are
1365 required to capture the SAW actuation of the liquid, but the resulting streaming occurs
1366 over a relatively large time scale and large spatial dimensions ²⁷.
- 1367 • Biological effects of acoustic actuation should be studied at microscopic and
1368 nanoscopic length scales and at various time scales.
- 1369 • Effective nanofabrication and measurement techniques should be utilized to construct
1370 nanofluidic devices and study their nanoscale acoustofluidic behaviors.

1371 **Device and technique innovations –**

- 1372 • Various substrates and thin film materials, such as those for flexible or wearable ones,
1373 polymer-based or hybrid materials with tailored acoustic properties, or new functional
1374 platform (e.g., phononic crystals) should be explored for new applications.
- 1375 • Alternative materials such as electroactive polymer materials technologies apart from
1376 a piezoelectric material, or electrets (which have properties much like human muscle
1377 tissue) could be explored to design and transform energy between electrical and
1378 mechanical forms comparable to piezoelectric materials.
- 1379 • Disposable superstrates should also be investigated, such as a traditional Petri dish^{311,347}
1380 or multi-well plates³⁴⁸, which can make a single SAW-based device reusable and
1381 economical by exchanging the superstrates ²⁷.

1382 • Alternate acoustic modes other than SAWs and BAWs could also be explored, which
1383 offer unique innovations ²⁷, such as flexural waves^{349,350} (Wedge acoustic waves) with
1384 acoustic black holes³⁵¹.

1385 • Improving heat management methods ⁵⁰ is important as the heat can affect the sound
1386 velocity and hence the resonant frequency. Additionally, heating control is valuable as
1387 streaming relies on the acoustic wave being attenuated.

1388 **Standardization and commercialization –**

1389 • Characterization of the biological effects of the acoustic actuation with the specific
1390 frequencies and powers should be standardized so that biomedical researchers can
1391 ensure that this technology is suitable for their research or applications ⁵⁰.

1392 • Open-source codes to compute the acoustic field generated by IDTs should be
1393 developed in designing and employing IDT devices for automation and precision
1394 control ⁵⁰.

1395 • All-in-one acoustofluidic prototypes would be advantageous for biomedical research
1396 laboratories, which are not need access to external equipment or a high degree of user
1397 skills or training, integrated with modern technologies such as mobile phone, touch
1398 screen, and Bluetooth, internet ⁴⁹.

1399 • Costs should be the key consideration for developing the future acoustofluidics devices.
1400 The end goal would be their commercialization, ideally with on-chip functionality
1401 without requiring extensive and costly external additional equipment such as power
1402 supplies, capillary pumps, lasers, and mass spectrometers - all of which at costs
1403 acceptable to manufacturers and consumers ⁴⁸.

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1408 [EP/N032861/1] Special Interest Group of Acoustofluidics.

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